1050 Series of HPLC Modules

Service Handbook -Variable Wavelength Detector (79853C)





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IMPORTANT NOTE

This version of the 1050 service manual includes all sections from the 01050-90102 edition 4 (1995).

The series I opticals information (79854A MWD) and the 79853A VWD information has been removed (products went out of support during 2000).

Part numbers have been updated as of 11/2001. Contact your local Agilent support office in case of part number issues or upgrades.

The latest version of this manual is available as Adobe Acrobat Reader (PDF) version only and can be downloaded from the Agilent Technolgies web page www.agilent.com.

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VWD: General Information

This chapter provides general information about the 1050 Variable Wavelength Detectors

VWD: General Information

This chapter gives general information on

- about this detector
- repair policy
- specifications

VWD: General Information About the Detector

About the Detector

The 1050 Variable Wavelength Detector (VWD) is a detector of the modular type liquid chromatograph 1050 Series. This is a standalone grating/photodiode type general purpose detector. The performance and features match the requirements of the routine analysis and QC/QA analysis. The 1050 VWD is a standard size detector of 1050 modular type LC series and can be build up with other LC modules, such as pump and automatic sampler. Since it is standalone type, it can be also used as an ordinary LC detector. It has a functional keyboard and 16-character fluorescent display which provides you easy operation.

Versions vs. Support Periods (EOS)

79853A

• The 79853A VWD was shipped between May 1988 and January 1992. The support with parts ended November 1, 2000.

79853C

- The 79853C VWD replaced the model 79853A VWD in January 1992. The end of support (EOS) will be August 1, 2006 with all 1050 series HPLC modules.
- The 79853C VWD got a redesigned optical unit ("D" enhanced optical, see "VWD: Enhanced Optical Unit Information" on page 705) that replaced the original "C" optical unit in June 1995. The end of support (EOS) for the "C" optical unit parts will be August 1, 2006 with all 1050 series HPLC modules.

Repair Policy

The 1050 VWD is designed that you can access all components easily. You can recalibrate wavelength using control functions. Customers are able to maintain certain parts of the 1050 VWD see *Operator's Handbook*.

For details on repair policy refer to "Repair Policy" on page 38 in chapter 1050 Common Information.

Specifications

Table 1

Specifications of 79853C VWD

Detection Type	Double beam photometer.	
Noise	< 1.5 x 10 ⁻⁵ AU peak-to-peak at 254 nm, flowing water at 1 ml/min, 1 second response time (10-90%) standard flow cell.	
Drift	< 5 x 10 ⁻⁴ AU/hour at 254 nm after warm-up.	
Wavelength Range	190 - 600 nm, settable in 1 nm increments.	
Wavelength Accuracy	±2 nm.	
Wavelength Reproducibility	±0.3 nm.	
Bandwidth	6.5 nm.	
Linear Absorbance Range	Better than 1% up to 1.2 AU using acetone at 265 nm.	
Response Time	0.25, 1 or 4 seconds (10-90%); user-selectable.	
Spectra	Storage of 1 spectrum during run; scan rate 10 nm/sec; range from 190 to 600 nm, selectable. Post-run plotting speed from 1 to 50 nm/sec selectable; plotting of background-corrected spectrum.	
Light Source	Deuterium lamp from 1090/40/50 DAD.	
Flow Cells	Standard 14 µl volume, 8 mm pathlength cell with 40 bar (588 psi) pressure maximum. Optional micro, preparative, high-pressure cells are available.	
Display	Single line, 16 character fluorescent display with real time display of operating parameters and/or absorbance.	
Control	Integrated keyboard with function keys; parameter editing during run possible; keyboard lock; optional control by computer or 3396 Series II integrator.	

Table 1	Specifications of 79853	Specifications of 79853C VWD				
	Parameters	Wavelength, output range, response time, zero, offset, balance, spectrum acquisition.				
	Diagnostic Aids	Wavelength calibration check with Holmium oxide filter.				
	Time-programs	Time-programmable wavelength and output range; storage of up to 5 time-programs.				
	Analog Output	One output user-configurable as recorder or integrator. For recorder: 100 mV or 1 V output range from 0.001 to 4 AU, user-selectable; for integrator: 100 mV/2 AU full scale or 1 V/2 AU full scale, user-selectable.				
	Communications	START (input/output), STOP (input/output), READY (output), SHUTDOWN (output) for synchronization with other LC modules.				
	Safety Aids	Extensive diagnostics, error detection and display via front-panel LED's. Leak detection, safe leak handling, leak output signal for shutdown pumping system. Low voltages in major maintenance areas.				
	Environment	Temperature range: 5 to 55°C				
		Humidity: < 95% (non-condensing)				
	Power Requirements	Line voltage: 100-120 or 220-240 VAC ±10%				
		Line frequency: 48-66 Hz				
		Power consumption: 150 VA max.				
	Dimensions	Height: 133 mm (5.2 inch)				
		Width: 325 mm (12.8 inch)				
		Depth: 545 mm (21.5 inch)				
		Weight: 14 kg (31 lb)				

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VWD: Hardware Information

This chapter provides hardware information about the 1050 Variable Wavelength Detectors

VWD: Hardware Information

	Overview	Overview					
NOTE	The information in this "C"). In June 1995 this o overcome baseline stab	"he information in this chapter is based on the original optical unit (version C"). In June 1995 this optical was replaced by the enhanced version "D" to vercome baseline stability problems in unstable environments.					
	For details on this "D" v Information "VWD: Enh	For details on this "D" version refer to section Enhanced Optical Unit Information "VWD: Enhanced Optical Unit Information" on page 705.					
	Figure 206 on page 567	Figure 206 on page 567 shows the block diagrams of the 1050 VWD 79853C.					
	The main components a	are:					
Table 1	Main Components Overvi	ew					
	Component	Purpose					
	Power Supply (DPS-A)	provides all voltages within the instruments					
	Detector Controller Board (DCB)	controls power supply, grating stepper motor, cutoff filter, keyboard, display and GPIB interface. It processes the signals coming from the pre-amplifier boards (sample and reference), the information from the grating and filter position sensor, leak sensor, remote control lines and the GPIB interface.					
	Optical Unit	contains all optical parts					
	Keyboard/Display	entry and display of parameter					
	GPIB Interface	communication with external controllers via GPIB					

VWD: Hardware Information **Overview**

Figure 1 Block Diagram of VWD



Optical System Overview

Figure 207 shows the optical diagram of the 79853C VWD. The radiation from the deuterium lamp is focused on a spherical mirror (M1). The light beam passes then a plane mirror (M2) the cutoff filter, the entrance slit, a spherical mirror (M3), the grating, again a spherical mirror (M4), a beam splitter and the flow cell to the sample diode. The beam through the flow cell is absorbed depending on the solutions in the cell, where UV absorption takes place. The intensity is converted to an electrical signal by means of the sample photodiode. Part of the light is directed to the reference photodiode by the beam splitter to obtain reference signal for compensation of intensity fluctuation of the light source. A slit in front of the reference photodiode focusses the light. Wavelength selection is made by rotating the grating, which is driven directly by a stepper motor. This configuration allows fast change of the wavelength. The cutoff filter is moved into the lightpath above 370 nm to reduce higher order light.

Figure 2 Light Path of Detector



Leak Interface Assembly

To route waste from a module standing above the 1050 VWD to a module below a leak interface can be installed at the detector. It is part of the accessory kit.

Figure 3

Leak Interface



Leak Sensor Assembly

A drain is located at the bottom of the cell compartment and can be led to the waste container or the 1050 waste handling system (the VWD has to stand on top of another module when the leak interface is not used).

A leak sensor is located behind the front panel assembly (Figure 209). Solvent would cool the leak sensor (self heating thermistor). The resulting change in resistance, measured by comparators on the Detector Controller Board (DCB), would generate an error message and switch the deuterium lamp OFF.

In the 1050 System remote mode the leak message will turn off the pump.

Figure 4

NOTE

Leak Sensor Assembly





VWD: Hardware Information Fan Assemblies

Fan Assemblies

The instrument is equipped with two fans.

On the 79853C VWD, the fans are of different type:

HIGH type	this fan is located close to the lamp housing and runs with a higher speed
LOW type	this fan is located at the rear under the GPIB interface and runs with a lower speed

The fans are connected to +24 VDC on the DCB Board.

	The information in this chapter is based on the original optical unit (version "C"). In June 1995 this optical was replaced by the enhanced version "D" to overcome baseline stability problems in unstable environments. For details on this "D" version refer to section Enhanced Optical Unit Information "VWD: Enhanced Optical Unit Information" on page 705.
	The Optical Unit houses all parts, from the deuterium lamp to the photodiode pre-amplifiers.
NOTE	The repair level is component .
	The optical unit is also available as assembly.
Figure 5	Optical Unit

VWD: Hardware Information **Optical Unit**

Flow Cells

There are several flow cells available as stainless steel or as titanium version, see Table 138 on page 574. The flow cell (Figure 211) can be exchanged easily. No adjustments are necessary. After disassembling of the flow cell, gaskets and windows can be replaced (refer to section "Flow Cell Maintenance" on page 655).

There are several kits set up with replacement parts like gaskets and windows, see "Standard Flow Cell "C" (SST/Ti)" on page 693 and the



NOTE

Figure 6

At the outlet of the flow cell a defined peek capillary (from the accessories must be connected to build up a certain back pressure (noise reduction). See "Standard Flow Cell "C" (SST/Ti)" on page 693 and the following pages for parts.



Flow Cell Data

Table 2

	STD (SST)	UHP (SST)	MICRO (SST)	STD (TI)	PREP (TI)	
Maximum Pressure	40	400	40	40	40	bar
Pathlength	8	8	5	8	VAR	mm
Volume	14	14	1	14	VAR	μl
Inlet i.d.	0.25	0.25	0.10	0.25	0.80	mm
Inlet length	555	555	555	555	67	mm
Outlet i.d.	0.25	0.25	0.25	0.25	0.80	mm
Outlet length	67	67	67	67	100	mm
Outer diameter	1/16	1/16	1/16	1/16	1/16	inch

Used materials for SST flow cells: SST, quartz and PTFE or Polyimide HP cell

Used materials for TI flow cells: TI, quartz and PTFE

STD	Standard Flow Cell
HP	High Pressure Flow Cell (replaced by UHP early 1993)
UHP	Ultra High-Pressure Flow Cell (replaces HP early 1993), see details on <i>"Ultra High-Pressure Flow Cell" on page 575</i> .
PREP	Variable Preparative Flow Cell with volume of 0.9, 1.8, 4.4 or 8.8 µl depending on which gasket is used.
MICRO	Semi Micro Flow Cell

NOTEThe gaskets, windows and rings **are not compatible** with the high pressure
Cell (79853-60009 - OBSOLETE) that has been replaced by the ultra high
pressure Cellflow cell (79853-60013). See "Ultra High Pressure Flow Cell
(SST)" on page 697 for details.

Table 3	Correction factors for 79853C flow cells				
Flow cell type	Cell volume	Part number	Path length (nominal)	Path length (actual)	Correction factor
Standard flow cell	14 µl	79853-60000	8 mm	8.00 ± 0.19 mm	8/8.05
Standard flow cell TI	14 µl	79853-60011	8 mm	8.00 ± 0.19 mm	8/8.00
Micro flow cell	1 µl	79853-60010	5 mm	5.00 ± 0.19 mm	5/5.00
Ultra High pressure flow c	ell 14 µl	79853-60013	8 mm	8.00 ± 0.19 mm	8/8.00

Ultra High-Pressure Flow Cell

Typical applications of the high-pressure flow cells are:

- Hyphenated systems (LC-MS)
- Supercritical Fluid Chromatography (SFC)
- Multidetector systems
- Narrow-bore column applications

The main difference between the standard and high-pressure flow cells is the design of the window assemblies. The high-pressure flow cells have different windows, seal ring and gaskets, see Figure 212. The seal rings support and hold the window and at the same time form the high-pressure seal.

NOTEThe gaskets, windows and rings **are not compatible** with the high pressure
Cell (79853-60009 - OBSOLETE) that has been replaced by the ultra high
pressure Cellflow cell (79853-60013). See "Ultra High Pressure Flow Cell
(SST)" on page 697 for details.

The following materials are in contact with solvents: Stainless steel (AISI 316), Quartz, Kapton[®] polyimide (Kapton is a registered trademark of DuPont).

Recommended pH range: 2.3 to 9.5

VWD: Hardware Information **Optical Unit**





Deuterium Lamp

On the 79853C VWD, the deuterium lamp (Figure 213) is the high intensity lamp (79883-60002), which is same as in the 1040/90/50 series Diode Array Detectors.

The reduction of energy emission of the lamp (Figure 214 on page 577) is time and wavelength dependent and is significantly higher within the first days and for wavelengths in the ultra violet range compared to the visible range (change in transmission of lamp glass).

Usually, the response maximum of the lamp is near 230 nm, but can be shifted to a higher wavelength for an aged lamp. It has no relevance for intensity degradation at other wavelengths.

The deuterium lamp filament is heated only during the ignition phase. The deuterium lamp can be exchanged easily. The lamp needs no adjustments.

VWD: Hardware Information
Optical Unit





Figure 8



Intensity Degradation of Lamp (79883-60002)



- Measured wavelength is 230 nm
- initial intensity about 20% higer than 79880-60002
- decrease in intensity is less with use

VWD: Hardware Information **Optical Unit**

NOTE	The lamp should be replaced only if the following two criterias are both fulfilled:
	Baseline Noise (with test cell) has increased significantly.
	Amount of counts of the lamp (with test cell) has decreased to less than 50% of the count record of this same lamp when newly installed).
	The decision to replace the lamp due to criterium 2 alone is not relevant, because the signal/noise may be still within instrument specifications.

Photodiodes Assemblies

Two photodiode assemblies (Figure 215) are installed in the optical unit. The sample diode assembly is located at the right side of the optical unit. The reference diode assembly is located in the front of the optical unit.

NOTE Neither, the diodes nor the pre-amplifier boards are interchangeable.

Refer to "Replacing Pre-amplifiers or Photodiodes" on page 667 for cleaning.

Figure 10 Photodiode Assemblies

NOTE





sample diode

reference diode

Filter Assembly

On the 79853C VWD (Figure 216), the Filter Assembly has a three filters [1] installed and is processor controlled. It can move into four positions:

OPEN	nothing in lightpath at wavelength < 370 nm
CUTOFF	cut off filter in lightpath at wavelength > 370 nm
DARK	O order calibration filter to reduce the light throughput to the photodiode during grating calibration at O order light
HOLMIUM	holmium filter for grating motor alignment

A photo sensor [3] determines the correct position.

Refer to "Replacing Filter Assembly Parts" on page 670 for cleaning.

Figure 11 Filter Assembly

NOTE



VWD: Hardware Information **Optical Unit**

Grating Assembly and Motor

The Grating has 1200 lines/mm and is directly rotated by the Grating Drive Stepper Motor, depending on the wavelength entry. The whole range (190...600 nm) is equal to 1238 steps (15.5°). The step angle of the stepper motor rotation is 3.75° and is reduced to 1/300 by a gear mounted directly to the motor shaft. The stepper motor is controlled and driven by the Detector Controller Board (DCB). The stepper motor reference position is determined by a plate fitted on the motor shaft interrupting a beam of a photo sensor.

The wavelength calibration of the grating is done at the 0 order light position and at at 656 nm, which is the emission line of the deuterium lamp.

If the motor assembly has to be exchanged it is necessary to do a compensation of motor tolerances. Refer to *"Replacing Grating Assembly Parts" on page 668.*

Figure 12 Grating Asembly



NOTE

The grating is coated with magnesium fluoride. The grating surface should not be touched or cleaned (see also *"Replacing Grating Assembly Parts" on page 668*). This will destroy the surface and reduce the light reflection.

Mirrors

The instrument contains four mirrors (M1, M2, M3, M4). Three of them are spherical type, one plane. On M2, M3 and M4 the beam height is adjustable. Mirror M3 and M4 are identical.

NOTE The mirrors are coated with magnesium fluoride. They should not be touched or cleaned (see also *"Replacing Mirrors, Beamsplitter and Slits" on page 670*). This will destroy the surface and reduce the light reflection.

Slit Assemblies

The instrument has two slit assemblies. The first slit is located at the light entry into the main optical compartment and focused the light on mirror M3. The second slit is in front of the reference diode.

Beam Splitter

The beam splitter splits the light beam. One part goes directly to the sample diode. The reference diode gets the other part. The height of the light beam is adjustable.

Refer to "Replacing Mirrors, Beamsplitter and Slits" on page 670 for cleaning.

Enhanced Optical Unit ("D")

In June 1995 this original optical unit was replaced by the enhanced version "D" to overcome baseline stability problems in unstable environments.

For details on this "D" version refer to section Enhanced Optical Unit Information "VWD: Enhanced Optical Unit Information" on page 705. VWD: Hardware Information Enhanced Optical Unit ("D")
1

VWD: Electronic Information

This chapter provides electronic information about the 1050 Variable Wavelength Detectors

VWD: Electronic Information

This chapter gives information about the electronic of the 1050 Variable Wavelength Detector:

- Overview
- Interconnection Diagram
- Detector Controller Board (DCB)
- Power Supply (DPS-A)
- Keyboard/-electronics
- Pre-amplifier Boards
- Power Supply Connection Board (PSC)
- GPIB Communication Interface

Location of Electronic Assemblies

In the 1050 VWD, the following electronic assemblies are available (for item numbers refer to Figure 218 on page 588):

Table 1	Electro	onic Assemblies	
	ltem	Description	
	1	GPIB Interface	
		Firmware ROM GPIB	
	2	Pan Assembly (LOW)	
	3	Fan Assembly (HIGH)	
	4	Connection Board (PSC)	
	5	Deuterium Lamp Assembly	
	6	Sample Diode Assembly (SDA)	
	6	Pre-Amplifier Board SAMP	
	7	Display Interface Board (KDI)	
	7	' Display Module (VFD)	
	8	Leak Sensor Assembly	
	9	Reference Diode Assembly (RDA)	
	9	Pre-Amplifier Board REF	
	10) Controller Board (DCB)	
	11	Firmware ROM DCB	
	12	Power Supply Assembly (DPS-A)	

VWD: Electronic Information Location of Electronic Assemblies



Interconnection Diagram

Figure 2 Interconnection Diagram



Detector Controller Board (DCB)

Repair Level: EPROM and Board

Table 2	Part Numbers for DCB				
	tem	Part Number	Comment		
	DCB (Exchange)	79853-69511	for use with PSC -66512		
	DCB	79853-66511	for use with PSC -66512		
	DCB	79853-66506 (OBSOLETE)	for use with PSC -66509 (OBSOLETE)		
	Firmware ROM DCB	79853-13005			
NOTE	If the DCB board i changed to 79853-	s replaced by 79853-665 66512.	11 version, the PSC board MUST be		
Main Functions	The main functions of the Detector Controller Board (DCB) are:				
	CPU				
	signal processing	display			
		analog output			
		digital input/outpu	t		
	A/D conversion				
	D/A conversion				
	control of Optical Uni	t deuterium lamp igr	nition		
		grating movement			
		filter movement			
		leak detector			
	remote control				



Digital Section

- CPU A 8-bit 1-chip Microprocessor 7810 is used as CPU. The 7810 includes 256 byte-RAM, 8 channel 8-bit A/D Converter, 16-bit timer/event counter, 2-channel 8-bit timer and two 8-bit I/O Ports. The Data Bus is 8-bit multiplexed with the address.
- **ROM/RAM/EEPROM** The ROM contains the firmware of the the detector and can be exchanged separately. In addition to the built-in functions, the 7810 has 64 Kbytel of external memory address and 32 Kbyte-ROM, 8 Kbyte-SRAM and 2 Kbyte-EEPROM are added.

The EEPROM contains:

- the time program;
- the grating calibration constant;
- D/A converter calibration constant;
- parameters set by key input (wavelength, range, response time, mode).

The main clock (24 MHz) is divided and distributed to:

24 MHz	A/D Converter Count Pulse
12 MHz	CPU Clock
6 MHz	D/A Converter Count Pulse
3 MHz	GPIB Controller, Key/Display Controller Clock
1.2 KHz	A/D Converter Integration period

After the power turns on, for about 100 ms the RESET signal is supplied to CPU, GPIB Controller and Key/Display controller. Also, anytime when power voltage becomes less than 4.7 V, the RESET signal is generated. The CPU controls directly the Buzzer and the Stepper Motor Driver to move the filters on the filter assembly.

The stepper motor for the grating, the input and the output port are connected to the internal BUS (DATA ADDRESS and CONTROL) and are controlled by the CPU. The grating motor and the filter motor are driven by a motor controller IC and phase pattern are coming from CPU.

Clock



Analog Sections

Signal Processing

The light beam from the SAMPLE and REFERENCE enters the photodiode respectively. Its current output is converted into a voltage by pre-amplifier. The gain of the pre-amplifier can be changed into four stages with CPU control.

The voltage signal from the pre-amplifiers are multiplexed and converted into digital form by a 18-bit A/D Converter. The conversion time of A/D Converter is 25 ms and is performed cyclically in the order of

Zero Sample-Reference

(Zero=GNDA)

Electrically zero calibration is done while balancing.

Digital data is transmitted to the CPU, digitally filtered based on response time and converted into the absorbance unit using the equation shown below:

 $AU = \log_{10}(REF) - \log_{10}(SAMP)$

The input voltage range of the integrator is -0.5..+9.5 V.



A/D Converter Method for the A/D conversion is feedback type Pulse Width Modulation (PWM).

Figure 6 A/D Converter



Positive or negative reference voltage is alternately added to the integrator. Duty cycles of each reference voltage is controlled by the output of a comparator connected to the output of integrator. Input voltage (U1) is converted to pulse width so that sum of both reference voltages is balanced with the U1. Clock voltage and \pm ES control this system and determines the period. The sum of clock voltage in one cycle is set to zero.

Pulse width, which is proportional to input voltage U1, is counted and is converted into a digital output.

The A/D converter has 18 bits resolution with 25 ms conversion time.

D/A Converter D/A converter combines a Pulse Width Modulator (PWM) and a 12-bit DAC. The lower 4 bits of the DAC pulse width modulated with 12 bit resolution is added to the upper 8 bits of the DAC. The upper 8 bits are also modulated by fixed pulse width so that the lower 4 bits balances to LSB of the upper 8 bits (pulse width is 15/16). The lower 4 bits are scaled to each bit of the upper 8 bits when using 44 : DAC CALIBRATION. The output of the 12-bit DAC is passed through a low-pass filter and 20-bit resolution analog signal is outputted to the BNC Connector. The cutoff frequency of a low-pass filter is set at 17 Hz while conversion frequency is 183 Hz.



Control of Grating Assembly	The wavelength is set by rotating the grating with a 2-phase stepper motor. The step angle of the stepper motor rotation (1 step angle 3.75°) and is reduced to 1/300 by a gear. The stepper motor is controlled and driven by DCB. The CPU contrls the motor controller IC that drives the motor. Stepper Motor reference position is determined by a plate fitted on the swing arm interrupting a beam of photo interrupter. The output signal of the photo interrupter is read by a 8-bit ADC of the CPU.
Control of Filter Assembly	The rotation of stepper motor controls the insertion of a different filters into the light path (cutoff, holmium, light reduction).
	The stepper motor is controlled and driven by DCB. The CPU controls the motor controller IC that drives the motor.
Remote Control	The REMOTE connectors communicate start or stop, error and not ready signal inputs and outputs.
	For detailed description of remote control refer to the 1050 Service Handbook, chapter Common Information.
NOTE	When the 79853C VWD is used in a system which is connected via remote, the VWD should be switched on as first module. Otherwise it may influence other modules at power on.
Leak Detection	The leakage from a flow cell is detected by change of Thermal Radiation Constant of NTC thermistor. Wheatstone bridge is constructed from NTC thermistor and resistors on the DCB. Its supply voltage is varied by controlling 24 V-power with Switching Regulator controller. The supply voltage is controlled to keep the thermistor at about 150 Ohm (150°C) constantly. If leakage occurs and the thermistor is soaked in the leaked liquid, the thermal radiation constant are changed and gives higher supply voltage at both ends of wheatstone bridge. This change is read by the CPU and compensated with ambient temperature.
	Error condition is when LS > LL. The values are visable with 33:LEAK TEST.





Change in Thermal Radiation Constant with surrounding temperature change is compensated by second NTC thermistor having same characteristics.





Table 3Test Connector J16

Pin	Purpose	Pin	Purpose	Pin	Purpose	Pin	Purpose	Pin	Purpose
1	Photocurrent REF	2	Photocurrent SAMP	3	+15 V	4	-15 V	5	Digital GND
6	+5 V	7	A/D Clock 1.2 kHz	8	Ref Voltage +10 V	9	Analog GND	10	

Power Supply (DPS-A)

Repair Level: Fuses and Exchange DPS-A

Table 4Part Numbers for DPS-AItemPart NumberDPS-A (Exchange)01050-69375DPS-A (New)5061-3375Fuse for 110 V operation 3 A2110-0003Fuse for 220 V operation 2 A2110-0002

For detailed information on the power supply refer the 1050 Service Handbook, chapter 1050 Common Information.

Lamp Ignition

The heater output made by a series regulator is in the pre-heating status 2.5 V always. After ignition a different output voltage is selected depending on the lamp type used: In the 79853C VWD the heater is switched off after ignition.

VWD: Electronic Information Keyboard

Keyboard

Keyboard

The flat keys at the front panel is composed of 6 x 4 matrix. Data is read by scanning at Key/Display Controller on the Keyboard Display Interface Board. Key entry is checked by reading the status of the controller by the CPU at every 10 ms. The Key/Display Controller also controls LED lamp lighting.

Figure 10



VWD: Electronic Information Keyboard

Keyboard Electronics (KDI / VFD)

Repair Level: Board

Table 5	Part Numbers for Keyboard Electron	ics			
	ltem	Part Number			
	Keyboard Display Interface (KDI)	79853-66502			
	Display Module Board (VFD)	79853-66503			
	Behind the frontpanel two electro Board (KDI) and the Display Mod	onic boards are located: Keyboard Interface ule Board (VFD).			
Keyboard Display Interface	The Keyboard Interface Board (K contains:	DI) is connected to the DCB board and			
	• interface between key-matrix (6 x 4) and DATA bus				
	• LED driver for the status messages ERROR, NOT READY, LAMP and RUN				
	• buzzer.				
Display Module	The Display Module Board (VFD)	is connected to the KDI and contains:			
	• CPU for control of latch driver				
	• latch driver for the Vacuum Fluorescence Display (FLD)				
	• DC/DC converter to provide the voltages for the FLD.				
	Refer to " <i>Replacing Display Boar</i> board.	rds" on page 662, when replacing this			

VWD: Electronic Information Keyboard





Pre-Amplifier Boards

Repair Level: Board

Part Numbers for Pre-Amplifiers

ltem	Part Number
Pre-Amplifier Board Sample	79853-66507
Pre-Amplifier Board Reference	79853-66508
Sensor Sample	79853-61109
Sensor Reference	79853-61110

The light (absorbtion) from the deuterium lamp (flow cell) is detected by the sample and the reference photodiode. Its current is then amplified by the pre-amplifiers. The signal then is routed to the DCB.

The wires from the photodiodes are soldered onto the board.

Figure 12 Photodiode Assemblies

Table 6





Power Supply Connection Board (PSC)

Repair Level: Board

Table 7	Part Numbers for PSC Board		
	ltem	Part Number	
	PSC Board (for DCB -66511)	79853-66512	
	PSC Board (for DCB -66506 OBSOLETE)	79853-66509 OBSOLETE	
NOTE	If the DCB board is replaced by 798 changed to 79853-66512.	53-66511 version, the PSC board MUST	be
	This board connects the Power Sup	ply DPS-A with the DCB and the	

Deuterium Lamp Assembly. The wires of the lamp cable are soldered in.

Figure 13 Board Layout PSC



GPIB Communication Interface

Repair Level: Board, Firmware

Table 8	Part Numbers for GPIB Interfac	e Board	
	ltem	Part Number	
	GPIB Board (with cable)	79853-68711	
	GPIB Cable to DCB Board		
	Firmware ROM GPIB	79853-13004	
Parallel Interface	Dual direction transceiver for aux code from DCB to GPIB DCB	data bus between master and board. 3 bit control code from	l slave CPU's. 8 bit 1 GPIB board to
Microprocessor	Single chip microprocessor w RAM and 32 I/O ports.	rith 1 Mbyte address capability	y, 512 byte internal
Memories	32 Kbyte of ROM for program	n memory and 128 Kbyte RAM	for the run buffer.
Firmware Description	The GPIB board performs all controller. DCB and GPIB bo Receiving GPIB commands th bit control code. This control commands, error codes or re or not. During run or monitor immediately to the GPIB board kind of bus data such as chroo line status or GPIB board cor The GPIB board writes the re out the formatted data adding	interruption processing from ard communicate with hardw he GPIB board passes them to code shows the kind of bus of questing data code and wheth mode the DCB send chromat rd with 8 bit aux code. This au matogram data, parameters, to trol code and whether the da ceived data into the run buffe g the start and the end record.	the GPIB are interrupts. the DCB with 3 data such as GPIB er the data ended togram data ix code shows the ime tables, remote ta ended or not. or. The GPIB sends
GPIB Address Setting	The GPIB address setting is a board. The factory setting is '	lone with a switch (1) at the r 10' (position A).	ear of the GPIB

VWD: Electronic Information GPIB Communication Interface

Figure 14 Location of GPIB board



GPIB Firmware Revisions

Refer to "GPIB ROM Firmware Revisions" on page 733 for information on firmware revisions.

1

VWD: Diagnostic & Troubleshooting Information

This chapter provides information on error messages and diagnostic features of the 1050 Variable Wavelength Detectors

VWD: Diagnostic & Troubleshooting Information

This section provides information on the

- diagnostic routines
- error messages
- user contol functions
- service control functions

Self Diagnosis

At power on and after lamp ignition the instrument checks itself for correct operation. In case of malfunctions, error messages will inform the operator on the fault.

During Power On

The following tests are done automatically during power on. They are described on the next pages together with the error message:

- Vaccuum Fluorescent display
- ROM and RAM
- Display
- Leak sensor
- Voltages
- A/D Converter
- EEROM Data
- Grating Drive

During Normal Operation

The following tests are done automatically during normal operation:

- for light intensity
- for filter movement
- for leaks

Error Messages Before Lamp Ignition

Error messages may come up during the power on state or the normal operation.

At Power ON

During power on the instrument run automatically through different selftest routines.

If all test are passed, the display shows HP 1050 VWD.

While initializing the CPU checks the response of the Vaccuum Fluorescent Display (VFD) module.

If there is no problem, SELF DIAGNOSIS IN PROGRESS is displayed.

If there is no response from the VFD, the ERROR lamp will light, the buzzer is heard for 2 seconds and is halted.

- □ Check connection DCB/KDI and KDI/VFD module.
- □ Replace VFD Module.
- □ Replace KDI Board.
- □ Replace DCB Board.
- □ Replace DPS.

ROM TEST FAILED The ROM Test calculates the checksum and compares it with a stored value. If a differrence is found, ERROR LED lights, ROM TEST FAILED is displayed and the CPU is halted. Otherwise ROM TEST OK is displayed.

- □ Replace EPROM.
- □ Replace DCB.

RAM TEST FAILED During RAM Test, firstly every RAM address is uniformly written. Then in ascending order, each address is tested for contents and then the data is inverted and written. Then the same procedure is repeated in decending order with the inverted data. This cycle is repeated twice. If an error is found, RAM TEST FAILED is displayed and further operation is prohibited. Otherwise, RAM TEST OK is displayed.

□ Replace DCB.

	VWD: Diagnostic & Troub Error Messages Before	leshooting Information			
Display Test	During Display Test every dot on the VFD module is set and you have to confirm it by yourself. If display is black or shows missing dots				
	□ Check connection	n of flat ribbon cable DCB to KDI.			
	□ Replace KDI.				
L.SENSOR TROUBLE	The Leak Sensor Test checks the leak sensor and the leak sensor circuit, but not for a leak resulting from the cell. The voltage applied is measured using built-in 8 bit ADC (A/D Converter) of the CPU as well as temperature compensation voltage from a second thermistor.				
	If the $LS > LL$, L.SEN	ISOR TROUBLE is displayed.			
	The range during tur	n on should be: LS:0.634.06 V and LL:2.824.00 V.			
	□ Use 33:LEAK S.VOLT to verify the values, (see message LEAK DETECTED.				
	Check connection	n of leak sensor to DCB.			
	□ Replace leak sens	sor.			
	□ Replace DCB.				
POWER FAILURE	During Voltage Test this message is displayed if the voltages exceeds the tolerance. If a voltage is not correct, it is displayed for a short moment, for example +24V TROUBLE.				
	□ Check voltages us	sing function 34: VOLTAGE TEST:			
Table 1	DC Voltages				
	Voltages	Used for			
	+ 12 V (±1 V)	filter and grating motor			
	- 15 V, + 15 V (±1 V)	analog circuits			
	+ 24 V (± 4.8V)	leak sensor, fans			

- □ Replace DCB.
- □ Replace Power Supply.

	VWD: Diagnostic & Troubleshooting Information Error Messages Before Lamp Ignition
ADC TROUBLE	During the A/D Converter Test the 18 bit ADC for photocurrent acquisition is tested with multiplexer channel fixed at analog ground. Pulse count for ground input is measured 20 times and calculate the average and the fluctuations. If the value exceeds the pre-determined value ADC TROUBLE is displayed.
	□ Replace DCB.
EEROM DATA LOST	During EEROM Data Test various parameters such as monochrometer parameter and time table are stored in EEROM (Electrically Erasable Read Only Memory) in order to save the value in absence of power. At initializing those values are checked using checksum. If an error is found, EEROM DATA LOST is displayed and default values are set.
	Different types of EEROM DATA LOST messages are possible:
EEROM DATA LOSTO	The key settable parameters (wavelength, responsetime, and so on) or time time tables are lost. They are replaced by default values.
	□ Re-enter the values.
	□ Replace DCB.
EEROM DATA LOST1	Wavelength parameter (zero order) are lost. They are replaced by default values. The monochromater parameters are differrent for each instrument.
	□ Execute 20:0th CALIB. or enter the 0th order parameter directly using 31:SET WL PARAM.
	□ Execute 45:WL COMPENSATE.
EEROM DATA LOST2	The DAC parameters are lost. The parameters are the scaling factors for each DAC bit and ZERO SPAN factors. The lost parameters are recoverable.
	□ Execute 44:DAC CALIB.
EEROM DATA LOST3	The DAC parameters are lost. The parameters are the offset parameter of the ADC reading for the output of each DAC bit (used for DAC calibration).
NOTE	These parameters can be re-written at the factory only.
	□ Perform 41:DAC TEST.
	If OK, then leave it as it is.

If NOT OK, then continue.

VWD: Diagnostic & Troubleshooting Information Error Messages Before Lamp Ignition

- □ Perform 44:DAC CALIB. The default values of the offset parameters are taken now.
- □ Perform 41:DAC TEST.

If OK, then leave it as it is.

If NOT OK, then replace DCB board.

- WL SET TROUBLEDuring the initialization of the grating motor position, the motor moves
backward to the home position where position sensor detects the limit. If it is
not able to detect the limit, WL SET TROUBLE is displayed.
 - **Check connection of position sensor and grating drive motor.**
 - □ Switch OFF lamp, remove top cover of optical unit to observe movement of grating mirror (changing wavelength).

If grating will not rotate after changing the wavelength, replace DCB or the Grating Driver Assy.

□ Using 36:GRATING P.S. you can move the grating shaft automatically or stepwise by pressing the down/up key. Normally in the position of about -200 steps, the output voltage of the position sensor will change from LOW to HIGH, detecting the limit position. If the output voltage will never change, the position sensor is defective or the grating drive assembly has a problem and has to be replaced.

	Error Messages After Lamp Ignition
LAMP ERROR	□ Check connections of lamp connector, PSC board and DPS to DCB.
	□ Replace lamp, DPS, DCB.
LOW ILLUMINATION	Light intensity of deuterium lamp is checked after lamp ignition at the wavelength of 250 nm. If the reference voltage at 250 nm is < 0.6 V, the detector will check the reference voltage at 500 nm and if < 0.12 V, LOW ILLUMINATION will be displayed. In this case the detector will never return to the original wavelength. It will remain at 500 nm.
	This test is skipped if WL SET TROUBLE is displayed and unable to set the wavelength.
	□ Check the lamp image on the entrance slit.
	If the image does not cover the slit properly, adjust mirror M1.
	□ Check connection to pre-amplifiers.
	□ Replace the lamp for deterioration of lamp.
	□ Replace the mirrors M1 and M2 for deterioration of mirrors.
FILTER ERROR	During Filter Test the second order light cutoff filter is tested by inserting it at the wavelength of > 370 nm and measuring the change of light intensity. If an error is found FILTER ERROR is displayed.
	This message comes up if
	• The reference current at 220 nm is more than 2.00 and at 500 nm more than 1/16 of the value at 220 nm. Then the filter is always off.
	• The photocurrent at 220 nm is less than 2.00 and at 500 nm more than 0.04. Then the filter is always ON.
	• The reference light beam is focussed far from the reference diode.
	□ Flow cell should be clean and bubble free.
	□ Check connection of filter motor.
	□ Check correct operation of filter with 39:FILTER TEST and photo sensor of filter with 37:FILTER P.S.
	Check beam splitter alignment.

	Error Messages During Normal Operation		
LEAK DETECTED	□ Enter service mode function 33:LEAK S. VOLT and check leak sensor voltages.		
	Error condition is wh	nen LS > LL. The normal range sho	ould be:
Table 2	Working Ranges for LS and LL		
	LS signal	LL signal	-
	2.352.85 V	2.953.45 V	_
	□ If there is no leakage, check the connection leak sensor to DCB.		
	Replace Leak Detector board.		
	Replace Leak Sensor	:	
DATA UNDERFLOW	This message may come up only during BALANCING when the sample or referrence voltage is lower than 1 mV.		
	Check, whether the f tightened.	low cell is in correct position and	the screws are
	□ Check the connectio	n of pre-amplifier sample to DCB.	
	□ Clean cell windows.		
	G Replace photo diode	assembly.	
	□ Replace DCB.		
DATA OVERFLOW	This message may come up only during BALANCING when the sample or referrence voltage exceeds 9.4 V.		
	Check, whether the flow cell is in correct position and the screws are tightened.		
	Replace DCB.		

VWD: Diagnostic & Troubleshooting Information Error Messages During Normal Operation

ADC OVERFLOW D Execute BALANCE, so that the proper pre-amplifier gain is selected.

- □ Check, whether the flow cell is in correct position and the screws are tightened.
- □ Is apature gasket installed in flow cell?
- □ Replace DCB.
- **No response for HPIB** set address switch correct.
 - □ check connection to DCB and GPIB cable.
 - □ change GPIB board.

Error Messages During Use of Control Functions

• When using 20:0th CALIB. this message may come up because the lamp is turned OFF or to much light reaches the sample diode.

□ Turn On the lamp.

□ Reduce light to sample diode.

• When using 21:WL CALIBRATION this message may come up under the following reasons:

If during scan the measured voltage of each step

is the same (Figure 232-a), or is on an upslope (Figure 232-b) or is on a downslope (Figure 232-c).

□ Use other wavelength setting to get a different range, 31:SET WL PARAM.

□ Recalibrate grating with 21:WL CALIBRATION.

Figure 1 Calibration Failure



User Control Functions

These functions are accessable for every instrument user. They are used for parameter settings and special operating functions during normal work.

Table 3

User Control Functions

#	Display	Used for	
1	1:SAMPLE SCAN	takes a sample scan	
2	2:REF. SCAN	SCAN takes a reference scan	
3	3:SPECTRUM OUT	PECTRUM OUT plots the spectrum	
4	4:SCAN FROM	defines scan range from	
5	5:SCAN TO defines scan range to		
6	6:ZERO OFFSET zero offset in %		
7	7:RESPONSETIME choices 0.25, 1 and 4 s		
8	8:AUTO LAMPOFF	automatic lamp off	
9	9:AUTO LAMP ON	automatic lamp on	
10	10:0UTP. DEVICE	integrator or recorder	
11	11:OUTPUT VOLT	1 V or 100 mV	
12	12:STATUS	FW revision, errors or status	
13	13:START MODE	local, remote, hpsystem	
14	14:0UTPUT CHECK	checks the output voltage	
15	15:RESET	reset to default	
16	16:PHOTOCURRENT	sample and reference diode's current	
17	17:PARAM. LOCK	LOCK locks certain parameters	
18	18:WL SHIFT	WL change on display	
19	19:POLARITY	polarity of signal (analog/GPIB)	
20	20:0th CALIB.	Oth order calibration	
User	User Control Functions		
------	------------------------	--	--
#	Display	Used for	
21	21:WL CALIBRATION	656 nm calibration	
22	22:HOLMIUMCHECK	WL Calibration check	
	User # 21 22	User Control Functions#Display2121:WL CALIBRATION2222:HOLMIUMCHECK	User Control Functions#DisplayUsed for2121:WL CALIBRATION656 nm calibration2222:HOLMIUMCHECKWL Calibration check

Functions 1 to 21 are described in detail in the User Documentation.

Service Control Functions

NOTE These functions are secured by a PASSWORD, because they are normally used by trained Service Engineers. Misuse of certain function may result in a misalignment of the optical path or electronical values.

If the VWD is in service mode, the ERROR status lamp blinks.

If the instrument enters into this mode accidentally, the easiest way to abort from this mode is: TURN OFF the power off the instrument.

Entering the Service Mode

- 1 Press [CTRL] [3] [0] [ENTER]
- 2 {30:SERVICE MODE} [ENTER]
- **3** {Pass Word} [1] [0] [5] [0] [ENTER]

This control function is the entry point for all service control functions. You can enter service control function only through this control function. Select your desired control function using [DOWN] or [UP]. Once you abort from this mode, you have to execute this function again. However if power has not switched off since last entry, you can skip password by just pressing [ENTER].

It is adviced that you will turn-off the power, after you finished using service control functions to avoid the accidental entry to service control mode.

In Table 151 on page 623 all service related functions are listed. Due to different firmware versions and improvements on 79853C VWD, the order of the functions is different.

The functions 20, 21 and 22 are part of the User Functions, but they are described in this section.

Table 4

Service Control Functions

#	Display	Used for
20	20:0th CALIB.	Zero Order calibration
21	21:WL CALIBRATION	656 nm calibration
22	22:HOLMIUMCHECK	Wavelength Calibration check
31	31:SET WL PARAM.	Parameter Set for Zero Order and 656 nm
32	32:FIX SIGNAL	Fixed voltage to sample or reference path
33	33:LEAK S. VOLT	Shows leak sensor voltages
34	34:VOLTAGE TEST	Shows DC Voltages
35	35:ADC NOISE	Check of ADC noise
36	36:GRATING P.S.	Check of Grating Sensor
37	37:FILTER P.S.	Check of Filter Sensor
38	38:REMOTE TEST	Check of Remote lines-
39	39:FILTER CHECK	Checks movement of Filter
40	40:0TH TEST OFF	Positions the Zero Order Beam
41	41:DAC TEST	Checks DAC
42	42:PREAMP GAIN	Checks linearity of gains
43	43:EEROM TEST	Checks EEROM data
44	44:DAC CALIB .	Calibrates the DAC
45	45:WL COMPENSATE	Compensates non-lineraties of grating

CAUTION

Important parameters might be lost. DO NOT use control functions 31 through 45 until you have read this paragraph and fully understand the functions and result of operation. Some functions may change the monochrometer parameters and misuse of these functions leads to inaccurate wavelength setting.

Zero Order Calibration

20:0th CALIB. This control function is used for the electrical calibration of the zero order beam of the monochrometer. The step number corresponds to the number in 31:SET WL PARAM.

> The grating is driven by the stepper motor through steps 150 to 250 searching for a maximum. The step number with the maximum voltage is displayed, and if accepted, written into the EEROM.

The intensity of the zero order light is reduced by inserting a filter in the calibration position automatically.

Prior to the use of this function, the grating assembly should be pre-aligned on the zero order light, using control function 40:0TH TEST OFF.

Table 5

Key Operation	Display	Description
	20:0th CALIB.	Select function.
ENTER	nn step CHANGE?	display current parameter or change to 200.
ENTER or		to continue calibration or
CLEAR		to abort.
		wait appr. 20 seconds.
	nn step x.xxxV	starts the calibration scan from 150 step to 250step
		No key entry is allowed here.
		Possible error message at this point may be:
	Calib. Failure	Indicates that the lamp is OFF.
	DATA OVERFLOW	Indicates that too much light reaches the sample photo diode. Reduce light and insert paper between cell and sample diode

Key Operation	Display	Description
	DATA UNDERFLOW	Indicates that not enough light reaches the sample photo diode. Check light path.
		The next line will be shown, if no error message occured.
	nn step y.yyyV	Displays the step that gave the maximum light intensity.
ENTER	nnn step OK ?	Promps for confirmation, to change the parameter.
ENTER		Takes the displayed step number.
CLEAR		Rejects the displayed step number.
ENTER	nnn step	New parameter is written in EEROM and monochrometer is reset with new parameter.
	20:0th CALIB.	End of Zero order beam calibration. You may repeat the procedure again.

Table 5 Control Function: Zero Order Calibration

Wavelength Calibration

21:WL CALIBRATION

This control function is used for the calibration of the monochrometer using the 656 nm line emission from the deuterium lamp. The step number appeared in this control function is the number of steps of stepper motor from the 0 order beam to the 656 nm emission line. Maximum light intensity is searched between ±50 steps of 656 nm value. If the maximum peak is found, the step number is written into EEROM and corresponds to the value in 31:SET WL PARAM.

Description Key Operation Display 21:WL CALIBRATION Select function. **FNTFR** Displays the wavelength for 656nm xxxx step calibration and steps based on present PARAM.WL 656. FNTFR or To continue calibration or **CIFAR** to abort. Wait appr. 30 seconds. xxxxstep y.yyyV Starts the calibration scan from 656 nm ±50 steps and seeks for maximum light intensity. No key entry is allowed here. Possible error message at this point may be: CALIB. FAILURE Indicates that there was no maximum found (see "CALIB FAILURE" on page 619). DATA UNDERFLOW Indicates that not enough light reaches the sample photodiode (<30 mV). The next line will be shown, if no error message occured.

Table 6

Control Function: WL Calibration

Key Operation	Display	Description
	xxxxstep y.yyyV	Displays the step that gave the maximum light intensity.
ENTER	656nm xxxx step	Displays the wavelength and step that gave the maximum light intensity.
after 2 seconds	656nm xxxxstep	Displays the new parameter at 546 nm and prompts the confirmation.
ENTER		Takes the displayed step number.
CLEAR		Rejects the displayed step
ENTER	656 yyyystepOK	New parameter is written in EEROM and monochrometer is reset with new parameter.
after 2 seconds	21:WL CALIBRATION	End of calibration. You can repeat the procedure again.

Control Function: WL Calibration

Table 6

Wavelength Calibration Check

22:HOLMIUMCHECK

This control function is used for the automatic check of the instruments WL calibrations using the some specific lines on the Holmium oxide filter which is moved into the light path.

Key Operation	Display	Description
	22:HOLMIUMCHECK	Select function.
ENTER	CHECK?	
CLEAR		to leave function.
ENTER		to start the calibration check
	360.8nm	automatic verification
	418.5nm	automatic verification
	536.4nm	automatic verification
	HOLMIUM CHECK OK	if within specification
CLEAR		to leave function.
DOWN	360.8nm 360.7nm	displays measured value
DOWN	418.5nm 418.4nm	displays measured value
DOWN	536.4nm 536.4nm	displays measured value
CLEAR	22:HOLMIUMCHECK	to leave function.

Control Function: HOLMIUMCHECK

Table 7

If this test was not successful, perform 20:0th CALIB. and 21:WL CALIBRATION.

SET WL Parameter

31:SET WL PARAM. This control function is used for the confirmation of monochrometer parameters or for changing them directly. PARM.WL0 is the number of steps of stepper motor from the position sensor, while PARM.WL656 is the number of steps from 0 order beam. As these values changes slightly from instrument to instrument, they are originally calibrated and written into EEROM.

The parameter 360.8 nm, 418.5 nm, 486 nm and 536.4 nm cannot be changed. These four parameters set with 45: COMPENSATE are used to compensate non-linearity of the grating drive.

If PARM.WL656 is changed, these four parameters are automatically shifted.

Key Operation	Display	Description
	31:SET WL PARAM.	Select function.
ENTER	Parm.WLO 200	Displays the 0 order light parameter (same
value found with 20:0th CALIB		
UP		Select the parameter WL656 nm.
	Parm. 656уууу	Displays the step number at 656 nm (same value found with 21:WL CALIBRATION.
		Enter the parameter using numeric keys.
UP	Parm.360.8yyyy	Displays the step number at 360.8 nm.
UP	Parm.418.5yyyy	Displays the step number at 418.5 nm.
UP	Parm. 486 уууу	Displays the step number at 486 nm.
UP	Parm.536.4yyyy	Displays the step number at 536 4 nm

Table 8

Control Function: SET WL PARAM.

 Key Operation
 Display
 Description

 ENTER
 31:SET WL PARAM.
 Control function is displayed again.

 CLEAR
 On WL0 or WL656 parameter, reenters the displyed value.

In order to change both parameters you have to repeat the above procedure for both wavelengths.

Fix Signal

32:FIX SIGNAL If the 1050 VWD shows noise or drift problems, this function can help to isolate the cause. The reference or the sample diode can be set to an fixed electrical value to remove influences from the light path.

> This function can also be used to retrieve the instrument profile of the instrument.

Key Operation	Display	Description
	32:FIX SIGNAL	Select function.
ENTER	REF. CH. FIXED	The photocurrent of reference photo diode is a fixed electrical value.
DOWN or UP		Select the parameter.
	NORMAL-NOT FIXED	Return to normal condition (neither photocurrrent is fixed.)
	SMP. CH. FIXED	The photocurrent of sample photo diode is a fixed value.
ENTER	32:FIX SIGNAL	Control function is displayed again.
	ENTER DOWN or UP ENTER	ENTER REF. CH. FIXED DOWN or UP NORMAL-NOT FIXED SMP. CH. FIXED ENTER 32:FIX SIGNAL

Table 9

NC returning to analysis mode from service control mode. This is an alarm to show that the instrument is abnormal condition. You can return to normal condition by executing NORMAL-NOT FIXED or switching off the power.

Use of FIX SIGNAL Use this function for

 \Box checking the noise of both sides separately;

□ taking the instrument profile of both sides separately.

With fixed signal, either the reference or the sample side is supplied with a constant current. So influences from the lamp effects only that side which is not fixed. Influence due to a drifting or defective photo diode effects both, a scan and the signal (noise). Small wavelength variations between fixed sample and reference scans are caused by the characteristics of the photo diodes.

Noise with Reference Signal Fixed: If the noise is large, the problem may be caused by light path, flow cell or sample diode/pre-amplifier.

Noise with Sample Signal Fixed: If the noise is large, the problem may be caused by light path, lamp or reference diode/pre-amplifier.

To take an instrument profile proceed as follows:

- □ Enter 32:FIX SIGNAL and set SMP. CH. FIXED.
- □ Press [ENTER] and leave function.
- □ Press [BALANCE].
- $\hfill\square$ Take a reference scan 2:REF SCAN.
- $\hfill\square$ Take a sample scan 1:SAMPLE SCAN.
- □ Set integrator to ATTN9, CS10 and Zero10%.
- □ Press [BALANCE].
- □ Enter 3:SPECTRUM OUT, press [ENTER] [ENTER].
- □ Start plot on integrator and press [ENTER]. The intensity profile is now plotted on the integrator.
- □ Perform above steps with REF. CH. FIXED to check the light through put of the cell. Figure 233 on page 633 shows both plots.



Figure 2 Example of Intensity Profiles

Leak Sensor Voltage

33:LEAK S.VOLT You can check the leak sensor with this contol function in case of trouble.

Table 10

Control Function: Leak Sensor Voltage

Key Operation	Display	Description
	33:LEAK S.VOLT	Select function.
ENTER	LS:2.70 LL:3.30	Displays LS (Leak Sensor Voltage) and LL (Temperature compensation voltage). Error condition is when LS > LL . The normal ranges are: LS signal 2.35.2.85 V, LL signal 2.953.45 V
CLEAR	33:LEAK S.VOLT	Leaves function.

Voltage Test

34:VOLTAGE TEST

You can check some (but not all) voltages with this contol function.

Table 11

Key Operation	Display	Description
	34:VOLTAGE TEST	Select function.
ENTER	15.0 22.9	Displays first set of voltages.
DOWN or UP	12.1 -15.0	Displays second set of voltages.
CLEAR	34:VOLTAGE TEST	Leaves function.

Table 12

DC Voltages

Voltages	Used for
+ 12 V (±1 V)	filter and grating motor
- 15 V, + 15 V (±1 V)	analog circuits
+ 24 V (± 4.8V)	leak sensor, fans

ADC Noise

35:ADC NOISE The output signal of the ADC noise corresponds to 196 AD counts at the Analog Output with 1 V full scale setting. The ADC noise must be within ± 10 counts (± 50 mV) over a time of 10 minutes (Figure 234).

Table 13

Control Function: ADC Noise

Key Operation	Display	Description
	35: ADC NOISE	Select function.
ENTER	TESTING ADC	ADC noise is outputted. Start plotter in ATTN 7, ZERO 50, Chartspeed 1 (on HP 339X)
CLEAR	35: ADC NOISE	Leaves function.



ADC Noise



Grating Photo Sensor

36:GRATING P.S. This control function can be used to check the function of the photo sensor and the drive mechanism of the grating. The movement of the grating can be done automatically or step for step. It will provide the step number and the voltage of photo sensor which detects the backward limit when the drive mechanism moves into the photo sensor. The photo sensor voltage exceeds 3 V when the photo sensor reaches at backward limit position.

A normal step value for change from LOW to HIGH is around -200 steps.

Key Operation	Display	Description
	36:GRATING P.S.	Select function.
ENTER	STPxxx PS0.11	Present step of stepper motor and photo sensor voltage is displayed.
DOWN or UP	STPxxx PSy.yy	You can move the stepper motor and observe the voltage.
ENTER	STP-nnn PS3.90	Starts automatically the search for the home position and displays the step number (nnn) and the corresponding voltage.
CLEAR	36:GRATING P.S.	Leaves function.

Table 14 Control Function: Grating Photo Sensor

Filter Photo Sensor

37:FILTER P.S. This control function can be used to check the function of the photosensor and the filter motor. The movement is done step for step. It will provide the step number and the voltage of photo sensor when the drive mechanism moves into the photo sensor.

Table 15	Control Function	Control Function: Filter Photo Sensor		
	Key Operation	Display	Description	
		37:FILTER P.S.	Select function.	
	ENTER	STPO PS4.98	Move to home position and shows steps and photo sensor voltage.	
DOWN	DOWN or UP	STPxxx PSy.yy	You can move the stepper motor and observe the voltage. When the motor leaves the photo sensor, then PS changes to 0.01.	
	CLEAR	37:FILTER P.S.	Leaves function.	
	Pressing			
	UP once rot	ates the filter 1 step (7.5°) to	the left.	
	DOWN once rot	ates the filter 1 step (7.5 $^\circ$ to	the right.	

Remote Test

38:REMOTE TEST This control function is to test the remote control line. Disconnect the remote cables to avoid interferrence to and from other instruments.

Remote lines tested are: START, SHUT DOWN, POWER DOWN, READY and STOP. PREPARE and START REQUEST are not tested.

Table 16 Control Function: REMOTE Test

Key Operation	Display	Description
	38:REMOTE TEST	Select function.
ENTER	Disconnect REMOTE Cab	le and Press START
START	REMOTE LINE TEST	The REMOTE LINE TEST starts.
	REMOTE LINE OK	When test is passed.
	REMOTE FAILURE	There's a trouble.
CLEAR	38:REMOTE TEST	Leaves function.

Filter Check

Table 17

39:FILTER CHECK This control function is used to check the motion of second order cutoff filter. The cutoff filter returns to original position at the end of this control function.

Key Operation	Concerning Display Description		
	39:FILTER CHECK	Select function.	
ENTER	CUT FILTER OFF	Displays present filter status	
DOWN or UP	CUT FILTER ON	Cutoff Filter moves in or out.	
CLEAR	39: FILTER CHECK	Leaves function.	

Zero Order Test

Table 18

40:0TH TEST OFF This control function is used to move the stepper motor into the zero order position and has to be performed during the alignment of the grating.

Key Operation	Display	Description
	40:0TH TEST OFF	Select function.
		The test is still off and the grating is on set parameter wavelength.
ENTER	Oth STEP NOnnn	Take the number of steps from 31:SET WL PARM. , (default) or use 200 steps.
ENTER	OTH TEST ON	The stepper motor is moved to zero order position.
CLEAR	40:0TH TEST OFF	Leaves function and grating is turned to set wavelength.

DAC Test

41:DAC TEST

This control function is used to check the D/A converter by setting different bits. An AC voltage is added to the DC output and should be $< 0.8 \times 10^{-5}$ AU.

Table 19 Control Function: DAC Test

Key Operation	Display	Description	
	41:DAC TEST	Select function.	
ENTER	TESTING BIT 0	Bit 0 is tested.	
UP	TESTING BIT 1	Bit 1 is tested.	
UP	TESTING BIT 2	Bit 2 is tested.	
UP	TESTING BIT 3	Bit 3 is tested.	
UP	TESTING BIT 4	Bit 4 is tested.	
UP	TESTING BIT 5	Bit 5 is tested.	
UP	TESTING BIT 6	Bit 6 is tested.	
UP	TESTING BIT 7	Bit 7 is tested.	
CLEAR	41:DAC TEST	Leaves function.	

Table 20

DAC DC Values

Bit	mV	Decription
0	27	
1	32	jump of 5 mV
2	42	jump of 10 mV
3	62	jump of 20 mV
4	104	jump of 40 mV
5	22	GND plus offset voltage
6	185	jump of 80 mV
7	511	about half of maximum output voltage

If you do not see a linear response, replace the DCB board.













If one or more tested bits are out of limit, then perform 44:DAC CALIB.

Pre-amplifier Gain

42:PREAMP GAIN This control function allows the check of gain switching on the DCB. The gain can be switched to 1, 2, 4 and 8.

Control Function: Pre-Amplifier Gain

Table 21

Key Operation	Display	Description
		Change wavelength to 500 nm to reduce intensity of light.
	42:PREAMP GAIN	Select function.
ENTER	G1 R0.115 S0.045	Shows the photocurrent of reference and sample side with gain 1.
DOWN	G2 R0.227 S0.089	Shows the photocurrent of reference and sample side with gain 2.
DOWN	G4 R0.455 S0.179	Shows the photocurrent of reference and sample side with gain 4.
DOWN	G8 R0.914 S0.358	Shows the photocurrent of reference and sample side with gain 8. The displayed values should double each time. If not, change wavelength to 500 nm or change DCB.
CLEAR	42:PREAMP GAIN	Leaves function.

EEROM Test

43:EEROM TEST This control function checks the EEROM and is used as factory test.

Table 22 **Control Function: EEROM Test Key Operation** Description Display 43:EEROM TEST Select function. EEROM TEST***** ENTER The blinking * indicates the checked section. EEROM TEST OK Test was successful. If test failes, replace DCB. CLEAR 43:EEROM TEST Leaves function.

DAC Calibration

44:DAC CALIB. This control function does a scaling between lower 12 bits and upper 8 bits of DAC and an automatic recalibration of the DAC internal voltages. It should be performed when the noise is higher than expected and a DAC non-linearity is found. The test runs automatically.

The initial calibration is done at the factory.

The lamp can be off, but the instrument should be on for some time for stabilizing the instrument to reduce drift.

Table 23

Control Function: DAC Calibration

Key Operation	Display	Description
	44:DAC CALIB.	Select function.
ENTER	Disconnect SIGNAL Cable and Press START	
START	DAC SCALING	Scaling starts.
	SCALING 0	Step 0 of 7 is displayed.
	f0 уууу	pre-scaling done for step 0.
		Now you steps 1 to 7 are done.
	DAC CALIB. OK	Calibration was successful.
ENTER	44:DAC CALIB.	Takes new factors and leaves function.
	DAC CALIB.FAILED	Calibration was not successful.
CLEAR	44:DAC CALIB.	Keeps previous factors when calibratio failed and leaves function.

Wavelength Compensation

45:WL COMPENSATE This control function is used to compensate non-lineratity of the grating drive.

NOTE If the grating motor or the grating has been replaced or moved, this function MUST be executed.

During this test, the flow cell should be empty (no windows) or clean filled with water or methanol (no air bubbles). Absorption in the flow cell causes an error.

- First step is to search for the 656 nm line emission of the deuterium lamp within a window of ±50 steps.
- Then the processor sets the ideal (linear) steps for four interpolative points, 360.8 nm, 418.5 nm, 486 nm and 536.4 nm.

360.8 nm and 418.5 nm are absorption points of the holmium oxide spectra. 536.4 nm is a line emission from the deuterium lamp.

- Next, it scans each ideal interpolative point (±25 steps) as reference.
- Then the holmium oxide filter is inserted and it scans again for the three absorption points of holmium oxide spectra (±25 steps).
- If all found values are in limit, then the parameters are written into EEROM (visable with 31:SET WL PARAM.).

Control Function: WL Compenstation

Table 24

Key Operation	Display	Description
	45:WL COMPENSATE	Select function.
ENTER	PARAM. CHANGE ?	
ENTER		to continue calibration
CLEAR		to abort calibration
	XXXstep y.yyyV	displays steps and voltage during calibration
	CALIB. FINISHED	new parameter, written into EEROM.

Table 24	Control Function: WL Compenstation			
	Key Operation	Display	Description	
	ENTER	45:WL COMPENSATE	Takes new factors and leaves function.	
		WL CALIB. FAILURE	one or more peaks could not be found with ±25 steps. Parameters are set to previous values.	
	CLEAR	45:WL COMPENSATE	Keeps previous factors when calibration failed and leaves function.	

1

VWD: Maintenance Information

This chapter provides provide procedures for service and maintenance of the 1050 Variable Wavelength Detectors

VWD: Maintenance Information

NOTE	The information in this chapter is based on the original optical unit (version "C"). In June 1995 this optical was replaced by the enhanced version "D" to overcome baseline stability problems in unstable environments.		
	For details on this "D" version refer to section Enhanced Optical Unit Information "VWD: Enhanced Optical Unit Information" on page 705.		
	Warnings		
WARNING	Dangerous voltage is present in the cabinet, though it is covered and insulated. DO NOT TOUCH PARTS unless they are specified in the procedure.		
	Be careful when you have to work in the optical unit. The lamp housing is hot.		
	Be sure to wear a pair of safety or sun glasses. Since the deuterium lamp emits intensive ultraviolet light, it is dangerous to perform optical alignment without eye protection. Be careful not to expose		

your eyes directly to the light coming from the lamp.

Securing for Transport

Figure 1

Securing for Transport



Replacement of Deuterium Lamp

If the Deuterium lamp no longer ignites or the lamp emission has become too low **and** noisy, the lamp has to be replaced.

The deuterium lamp is exchangeable by the user. No adjustment is necessary. For accurate wavelength setting excute user control function 20:0th CALIB. and 21:WLCalibration after exchanging the lamp.

Step 1: Replacement

- □ Turn the lamp off.
- □ Loosen the two screws at the rear of the instrument which fix the cover and remove them.
- □ Remove top cover.
- **U**nplug the lamp and remove it.
- **□** Exchange the lamp (no adjustment is required).
- □ Reconnect the lamp.
- $\hfill\square$ Replace top cover.
- □ Turn the lamp on.

VWD: Maintenance Information Replacement of Deuterium Lamp

Step 2: Oth Order Calibration

The instrument scans for the maximum of the zero-order light.

During 0th order calibration a filter for reducing light intensity to prevent ADC data overflow will be inserted automatically.

Select control function 20:0th CALIB.

[ENTER]	enters function
200step CHANGE?	displays the current parameter
[ENTER] or [CLEAR]	to continue or to abort
150step 0.000V	instrument scans now for maximum from step 150 to 250
201step X.XXXV	maximum when calibration successfully finished, press [ENTER]
201 step OK ?	press [ENTER] to keep the new value and to leave function

If CALIB. FAILURE occurs, press [CLEAR] to keep the old value and to leave function.

Step 3: WL CALIBRATION

The instrument scans for maximum light intensity of 656 nm line spectrum of deuterium lamp.

Enter control function 21:WL CALIBRATION.

[ENTER]	enters function
656nm 1900step	displays the current parameter.
[ENTER] or [CLEAR]	to continue or to abort
1875step 0.000V	the instrument scans now for for maximum for 100 steps
1902step X.XXXV	maximum when calibration successfully finished, press [ENTER]
656 1902stepOK?	press [ENTER] to keep the new value and to leave function.

If CALIB. FAILURE occurs, press $\ensuremath{\texttt{[CLEAR]}}$ to keep the old value and to leave function.

Flow Cell Maintenance

To replace or clean certain parts of the flow cell you should have a clean working area.

Refer to "Standard Flow Cell "C" (SST/Ti)" on page 693 and the following pages for detailed flow cell schematics.

Flow Cell Maintenance Kits

There are several maintenance kits available with replacement parts for the flow cells.

For details see "Standard Flow Cell "C" (SST/Ti)" on page 693 and the following pages.

Replacing Cell Parts

For the detailed procedures refer to the Operating Manual.

- □ Remove flow cell.
- □ Unscrew the cell screw using a 6 mm hexagon wrench, see Figure 238 on page 656, item 1.
- **□** Remove inner parts carefully and place them in the correct order in front of you.
- □ Replace window, gaskets or other parts as needed.

NOTE Once a gasket has been compressed or spoiled on the surface, DO NOT use it again. A used gasket may cause leakage.

- □ Insert all parts in the correct order.
- □ Tighten the cell screw.
- □ Perform a "Leak Test" on page 657.

VWD: Maintenance Information Flow Cell Maintenance



Standard Flow Cell



Flushing Procedure

Cleaning the cell (by using a glass syringe!)

- □ Flush with iso-Propanol.
- □ Flush with bidistilled water.
- \Box Flush with nitric acid : water (5 : 95).
- □ Flush with bidistilled water.
- □ Flush with iso-Propanol

CAUTIONThis concentration of nitric acide is dangerous and proper attention to safety
should be given. Also, the nitric acid flushing procedure is not a certain cure
for a dirty cell. It is to be used as a last attempt to salvage the cell before
certain cell parts have to be replaced.
Leak Test

Remove the flow cell and connect the outlet tubing of the flow cell directly to the pump. Then flow an appropriate solvent (for example Isopropanol) at 10 ml/min. After several minutes check the cell visually. If it is necessary to check it for higher pressure, put an appropriate stainless steel tubing which can build up a back-pressure.

CAUTION DO NOT apply higher back pressure to the flow cell than maximum pressure of the flow cell.

Table 1	Pressure Rating on Flow	Pressure Rating on Flow Cells			
	Туре	Pressure			
	Standard Flow Cell	40 bar			
	Ultra High-Pressure Cell	400 bar			
	Preparative Flow Cell	40 bar			
	Semi-Micro Flow Cell	40 bar			

Using the Cuvette Holder

When required:	If your own standard should be used to checkout the instrument
Tools required:	None
Parts required:	Cuvette Holder 79853-60016 Cuvette with the "standard", e.g. NIST certified holmium oxide sample
	This cuvette holder can be placed instead of a flow cell in the variable wavelength detector. Standard cuvettes with standards in it, for example, National Institute of Standards & Technology (NIST) holmium oxide solution standard, can be fixed in it.
	This can be used for wavelength verifications.
Figure 3	Cuvette Holder





Replacing DCB Board and Firmware

When performing one of these tasks, take care for electrostatic discharge protection to keep the electronics alive.

DCB Board

- □ Note the parameters from 31:SET WL PARAM.
- □ Disconnect the power from the instrument.
- **D** Remove main cover and disconnect all connectors from DCB.
- **□** Replace DCB after loosening the 3 fixing screws.
- □ Fix all screws and reconnect all connectors to the DCB.
- □ Carefully remove the firmware ROM from removed DCB and insert it on new DCB.
- **□** Replace main cover and turn the instrument ON.
- **u** Turn lamp on and wait some minutes to stabilize the lamp.
- □ Perform functions 20:0th CALIB., 21:WL CALIBRATION, 44:DAC CALIB. and 45:COMPENSATE to input the detector specific parameters into the EEROM.

DCB Firmware

- **D**isconnect the power from the instrument.
- □ Remove main cover.
- □ Carefully replace the firmware ROM.
- $\hfill\square$ Replace main cover and turn the instrument ON.
- **□** Turn lamp on and wait some minutes to stabilize the lamp.

Replacing Display Boards

- □ Remove front panel assembly and disconnect cables between front panel and DCB.
- □ Unscrew the six screws which hold the plastic part at the metal frame (except the two screws that fix the leak assembly).
- □ Disconnect the grounding cable and the cable between the two display boards.
- □ Replace the defective board.
- □ To loosen the flat cable [3] from the keyboard, press a flat screwdriver onto the two noses on each side of the connector [1] to release the upper part [2] of the connector.

Figure 4 Release of connector





Replacing the Leak Interface

Leak Sensor Assembly

- **□** Remove the flow cell.
- □ Remove top cover.
- □ Disconnect leak cable from DCB and the flat ribbon cable from DCB to keyboard at the KDI board.
- □ Unscrew the screws that fix the front panel.
- □ Remove front panel.
- □ Replace sensor board or complete assembly.

Figure 5 Leak Sensor Assembly





Leak Interface

- □ Carefully remove the leak interface.
- □ Replace the defective item. All three parts (top, bottom and tubing are coming together as kit).
- □ Install the leak interface.





	Replacements in the Optical Unit
	The repair level of optical unit parts is component level.
	Refer to section "Optical Unit "C"" on page 688 for additional parts.
NOTE	The information in this chapter is based on the original optical unit (version "C"). In June 1995 this optical was replaced by the enhanced version "D" to overcome baseline stability problems in unstable environments.
	For details on this "D" version refer to section Enhanced Optical Unit Information "VWD: Enhanced Optical Unit Information" on page 705.
WARNING	Be sure to wear a pair of safety or sun glasses. Since the deuterium lamp emits intensive ultraviolet light, it is dangerous to perform optical alignment without eye protection. Be careful not to expose your eyes directly to the light coming from the lamp.

Figure 7 Optical Unit



Removing the Optical Unit

- Disconnect power from instrument.
- □ Remove flow cell.
- **□** Remove top cover.
- Disconnect all cables that go from the optical to the Detector Controller Board (DCB).
- □ Place the instrument on its left or right side.
- **□** Remove all nuts that fix the optical unit.
- □ Take out the optical unit.

Replacing the PSC Board

- □ Refer to "Removing the Optical Unit" on page 666.
- □ Remove the PSC protection cover (2 screws).
- \Box Loosen the PSC board (3 screws).
- Remove the lamp supply connector from the fan assembly.
- □ Fed the wire carefully between fan cover and power supply cabinet. If not possible, loosen the fan cover.
- **□** Replace the PSC board and reuse the old cable to the DCB board.
- □ When replacing the PSC protection cover, take care for correct routing of the wire at the right side.

Replacing Pre-amplifiers or Photodiodes

- $\hfill\square$ Remove the top cover and the front panel assembly.
- □ Refer to Figure 244 for next steps.
- □ Remove the cover that protects the pre-amplifier.
- **□** To replace the pre-amplifier boards
 - $\hfill\square$ disconnect cable from pre-amplifier board
 - \Box unscrew the board
 - $\hfill\square$ unsolder the wire from the photodiode
 - □ replace the board.
- **□** To replace the photodiode
 - \square remove cover plate of photodiode
 - unsolder photodiode
 - unscrew photodiode
 - □ replace photodiode.



Location of Photodiodes



Replacing Grating Assembly Parts

Photo Sensor

- □ Refer to "Removing the Optical Unit" on page 666.
- **□** Remove the bottom plate of the optical unit.
- **U**nscrew the photo sensor and replace it.

Grating

For [] items refer to Figure 245 on page 669.

- **□** Remove the top cover of the optical unit.
- \Box Use a hex key (2.5 mm) to loosen the grating screw [2].
- □ Replace the grating [1].
- □ Refer to "Optical Alignment Procedures" on page 671.

Grating Motor

For [] items refer to Figure 245 on page 669.

- □ Refer to "Removing the Optical Unit" on page 666.
- □ Refer to "Replacing Grating Assembly Parts" on page 668 and take grating out.
- □ Remove the bottom plate of the optical unit.
- **□** Remove the two springs.
- □ Unscrew the three screws [6] that fix the motor assembly [5] and take it out. Keep spring [3] and gasket [4].
- □ Replace the spring [3], gasket [4] and complete motor assembly [5].
- □ Reinstall the grating [1].
- □ Refer to "Optical Alignment Procedures" on page 671.

Figure 9 Grating Assembly



Replacing Filter Assembly Parts

- □ Refer to Refer to "Removing the Optical Unit" on page 666.
- **□** Remove the bottom plate of the optical unit.
- □ Unscrew the 2 screws that fix the filter assembly.
- □ Take out the complete assembly.
- **□** Replace the complete filter assembly, sensor lever or the sensor.

Figure 10 Filter Assembly



Replacing Mirrors, Beamsplitter and Slits

- □ Open the optical untit's top cover.
- □ Replace the item that need to be replaced.
- □ Refer to "Optical Alignment Procedures" on page 671.

NOTE DO NOT touch the surface of the mirrors, beam splitter and the grating.

Optical Alignment Procedures

Procedure 1:	alignment after exchange of a specific part
Procedure 2:	alignment of complete optical (sample path)
Procedure 3:	alignment of complete optical (reference path)

WARNINGBe sure to wear a pair of safety or sun glasses. Since the deuterium
lamp emits intensive ultraviolet light, it is dangerous to perform
optical alignment without eye protection. Be careful not to expose
your eyes directly to the light coming from the lamp.

Procedure 1: Simple Alignment

When replacing just a single part in the light path other than grating parts, M4 and beam splitter, this procedure can be performed.

- □ Execute 40:0th TEST which shows the step number from 31: SET WL PARM. and watch the location of the images on the slit assemblies (entrance and reference slit) and the cell center.
- **D** Exchange the part Refer to *Replacing* ... for more information.
- □ Position the part so that the image centers on entrance and reference slit.
- Given Fix the part.
- □ If image on exit slit is too high or low, follow procedure "Procedure 2: Sample Beam Alignment" on page 672.
- □ If image on reference slit is too high or low, follow procedure "Procedure 3: Reference Beam Alignment" on page 674.
- □ Excute the 20:0th CALIB. and 21:WL CALIBRATION.
- □ Refer to "Replacement of Deuterium Lamp" on page 652, Step 2 and 3.

VWD: Maintenance Information Optical Alignment Procedures

Procedure 2: Sample Beam Alignment

For [] items refer to Figure 247.

- M1, M2, Entrance Slit,
 Remove the entrance slit [3].
 M3
 - \Box Turn the deuterium lamp [1] on.
 - □ Make sure the light spot covers over mirror M1 [4].
 - □ Adjust the direction of mirror M1 [4] so that the light beam covers over mirror M2 [5].
 - □ Adjust the angle and direction of mirror M2 [5] so that the light beam covers over mirror M3 [6].
 - □ Install the entrance slit [3] where the light beam illuminates the center of the slit.
 - □ Adjust the angle and direction of the mirror M3 [6] so that the light beam covers over the grating mirror [7].





VWD: Maintenance Information Optical Alignment Procedures

Grating, M4, Beam Splitter	Excute control function 40:0TH TEST OFF to set the grating motor position to 200 steps (center step number).
	Adjust the direction of the grating mirror [7] so that the light beam covers over the mirror M4 [6].
	Remove the beam splitter [8] now so that you can see the center of the flow cell.
	Adjust the angle and direction of the mirror M4 [6] so that the light beam illuminates the center of the flow cell.
	Leave control function 40:0TH TEST OFF and return to normal display.
	Excute the 20:0th CALIB. and 21:WL CALIBRATION. Refer to "Replacement of Deuterium Lamp" on page 652, Step 2 and 3.
	If grating has been moved, use 45: COMPENSATE to compensate non-linearity of the grating motor.
	Set wavelength to 254nm.
	Place cover on optical unit (do not fix the screws at this time).
M4 fine tuning	Excute control function 16: PHOTOCURRENT.
	Remove the blank screw for mirror M4 adjustment (Figure 243 on page 666) on the top cover (leave the blank screw for beam splitter adjustment in).
	Adjust the angle of the mirror M4 with inserting a hexagon wrench (1.5 mm) through the top cover screw hole to get maximum photocurrent for the sample. Turn right to move image down and left for up.
	Replace the blank screw in the top cover.
	Excute the 20:0th CALIB. and 21:WL CALIBRATION. Refer to "Replacement of Deuterium Lamp" on page 652, Step 2 and 3.

□ Install the beam splitter [8].

VWD: Maintenance Information Optical Alignment Procedures

Procedure 3: Reference Beam Alignment

For [] items refer to Figure 247 on page 672.

- □ Excute 40:0TH TEST ON with calibrated step value displayed.
- Open the top cover and adjust the angle and direction of the beam splitter
 [8], so that the light beam illuminates the center of the reference slit [12].
- \Box Place the cover on the optical unit.
- □ Leave 40:0TH TEST ON and set wavelength to 254 nm.-
- □ Remove the blank screw for beam splitter adjustment (Figure 243 on page 666) in the top cover.
- □ Excute 16: PHOTOCURRENT.
- Adjust the angle of the beam splitter inserting a hexagon wrench through the top cover screw hole to get maximum photocurrent for the reference. Turn right to move image down and left for up.
- □ Replace the blank screw in the top cover.
- □ Repeat the 20:0TH CALIB. and 21:WL CALIBRATION. Refer to "Replacement of Deuterium Lamp" on page 652, Step 2 and 3.
- □ Use 45: COMPENSATE to compensate non-linearity of the grating motor.

Cleaning of Optical Unit Parts

There are only a few parts within the optical unit that can be cleaned.

Table 2	Cleanable Optical	Cleanable Optical Parts			
	NOT CLEANABLE	grating and all mirrors			
		Touching or cleaning will result in decrease of reflaction/intensity			
	CLEANABLE	filters (holmium, cutoff and 0 order calibration), beam splitter, photo diodes			
		You can wipe the surface with ethanol. In case you cannot remove stains, the part has to be replaced.			

Upgrade to GPIB

- □ Note the values for WL, 0 and 656 nm using 31:SET WL PARAM., just in case the EEROM looses the values.
- **□** Turn off the instrument.
- **□** Remove top cover of the instrument.
- **□** Remove plate at the rear panel above the fan.
- □ Install the GPIB board in that location using the screws that hold the plate.
- □ Connect the GPIB cable to J12 of the DCB board.

GPIB Address Setting

The GPIB address setting is done with a switch (1) at the rear of the GPIB board. The factory setting is '10' (position A).

Figure 12 Location of GPIB board



Performance Verification

 Table 3
 Noise and Drift Specifications

 Noise
 1.5 x 10⁻⁵ AU

 Drift
 5.0 x 10⁻⁴ AU/h

What you need

- □ a pump that can deliver bidistilled water, at a rate of up to 1 ml/min against a back-pressure of about 200 bar.
- □ a column: we recommend our 100 x 4.6 mm i.d., 5 µm Hypersil ODS column.
- □ a recording device that can accept the output signal from your detector and that has attenuation set to about 35 cm/mV.

Preparations

- □ Prime the pump and ensure there are no air bubbles in the system.
- □ Thoroughly degas about 300 ml of bidistilled water.
- □ Set pump to deliver bidstilled water at a flow rate of 1 ml/min.
- \Box Set the attenuation to about 35 cm/mV.
- □ Set run time on recorder to 6.0 min.
- □ Turn-ON line power and deuterium lamp.
- Set wavelength to 254 nm, response time to 1 second and output voltage to 1 V.

VWD: Maintenance Information **Performance Verification**

Starting a run

- Give the optical unit time to warm-up and stabilize.
- □ Start a run.

The baseline noise should not exceed 7.5 μV (1.5 x 10^{-5} AUI) equivalent to 4.5 mm at attenuation - 3 on a 3390/2/3 integrator and equivalent to 9 mm at attenuation - 3 on a 3394/6 integrator.

Figure 13 Example of Noise Plot



This plot was taken with

- a 79853C VWD
- an 35900C A/D converter
- a LC DOS workstation
- flow cell windows removed, but gasket #2 installed.

It shows, that the drift on this example is $<1 \ x \ 10^{-4} \ AU/hr$ and the noise at about $<1 \ x \ 10^{-5} \ AU.$

Scaling Factors

The table below shows the scaling factors for the 339XA family of integrators. The 3390A, 3392A and 3393A have a full scale deflection of 75 mm. The 3394A and the 3396A have a full scale deflection of 150 mm, they also have an attenuation range between -8 and 36.

ATTN	mV full scale	mAU full scale	
-3	0.125	0.25	
-2	0.25	0.5	
-1	0.5	1	
0	1	2	
1	2	4	
2	4	8	
3	8	16	
4	16	32	
5	32	64	
6	64	128	
7	128	256	
8	256	512	
9	512	1024	
10	1024	2048	

Table 4

VWD: Maintenance Information Performance Verification

1

VWD: Parts Information

This chapter provides information on parts of the 1050 Variable Wavelength Detectors

VWD: Parts Information

This chapter gives diagrams for parts identification and the complete parts listings respectively.

- Overall Diagram
- Optical Unit
- Flowcell
- Flow Cell Kits
- Accessory Kit

NOTE The information in this chapter is based on the original optical unit (version "C"). In June 1995 this optical was replaced by the enhanced version "D" to overcome baseline stability problems in unstable environments.

For details on this "D" version refer to section Enhanced Optical Unit Information "VWD: Enhanced Optical Unit Information" on page 705.

Overall Diagram

Table 1Overall Diagram

ltem	Description	Part Nmber	ltem	Description	Part Nmber
1	Power Supply (5061-3375)	01050-69375	15	Cover Assembly	79853-64101
2	DCB Board Assembly, see *	79853-69511	16	GPIB Board Assembly	79853-68711
2	ROM DCB Firmware "C" only	79853-13005	16	ROM GPIB Firmware	79853-13004
2	ROM DCB Firmware "D" only	79853-13000		Cable DCB-GPIB	79853-61610
3	PSC Board for DCB 79853-66511	79853-66512	17	Fan Assembly (LOW)	79853-68503
4	Cable PSC-DCB	79853-61605	18	Cover Fan	79853-04102
5	Cover PSC	N.A.	19	Sheet Fan	N.A.
6	Leak Sensor Board	see page 687	20	Fan Assembly (HIGH)	79853-68502
7	Leak Sensor Assembly	see page 687	21	Switch Bearing	79853-61903
8	Sheet Front Panel	see page 687	22	Switch Bracket	N.A.
9	Front Panel Assembly	see page 687	23	Switch Shaft	79853-61901
10	Display Interface (KDI)	79853-66502	24	Switch Top	79853-61902
11	Display Module (VFD)	79853-66503	25	Cable DCB-KDI	79853-61609
12	Cable KDI-VFD	79853-61602	26	Optical Unit	see page 688
13	STD Flow Cell Assembly	see page 693			
13	Semi-micro Flow Cell Assembly	see page 695		Transport Screw Kit, contains 3 screws with washer and spacer	79853-68700
13	Ultra High Pressure Flow Cell Assembly	see page 697		PEEK Inlet Tubing Kit	5062-8522
13	Prep Flow Cell Assembly TI	see page 698		PEEK Waste Tubing Kit	5062-8535
14	Bracket DPS	N.A.			

* If installed in instruments with PSC -66509, then PSC must be updated to 79853-66512.

VWD: Parts Information **Overall Diagram**



VWD: Parts Information **Overall Diagram**



Front Panel Parts

Leak Interface

Table 2 Leak Interface Description Part number Leak Interface Kit, contains 79853-68731 Top, Bottom and Tubing Figure 3 Leak Interface Тор Tubing Bottom

VWD: Parts Information
Front Panel Parts

Font Panel

Table 3	From	Front Panel				
	#	Description	Part number			
		Front Panel Complete	79853-60203			
		Front Panel	79853-60202			
		1 Leak Sensor Board	79853-66510			
		2 Leak Sensor Assembly	79853-66111			
		3 Display Module Board (VFD)	79853-66503			
		4 Cable KDI-VFD	79853-61602			
		5 Display Interface (KDI)	79853-66502			
		6 Cable DCB-KDI	79853-61609			
		O-ring, Leak Assembly	79853-82501			



Front Panel



Optical Unit "C"

The parts identification of the optical unit is splitted into four sections:

- Optical Unit Inner Parts (Top)
- Optical Unit Inner Parts (Bottom)
- Grating Assembly
- Filter Assembly
- Flow Cell Assemblies

NOTE The information in this chapter is based on the original optical unit (version "C"). In June 1995 this optical was replaced by the enhanced version "D" to overcome baseline stability problems in unstable environments.

For details on this "D" version refer to section Enhanced Optical Unit Information "VWD: Enhanced Optical Unit Information" on page 705.

For complete optical unit "C" replacements use part number 79853-60015. This upgrades to "D" version, see "Part Numbers for Enhanced "D" Optical Unit" on page 709

VWD: Parts Information Optical Unit "C"

Optical Unit "C" Inner Parts Top

Table 4 Optical Unit "C" Inner Parts TOP

Item Description	Part Nmber	Item Description	Part Nmber
Optical Unit (complete assembly)	79853-69015	7 Grating Assembly	see page 69
Plate Optical Top	79853-04108	8 Beam Splitter	79853-20402
1 Deuterium Lamp Assembly	79883-60002	9 Pre-Amplifier Board, SAMPLE	79853-66507
Lamp housing	79853-22006	10 Sensor, Sample	79853-61109
2 Filter Assembly	see page 692	11 Pre-Amplifier Board, REF	79853-66508
3 Entrance Slit Assembly	79853-23103	12 Sensor, Reference	79853-61110
4 Mirror #1	79853-68107	Reference Slit	79853-23104
5 Mirror #2	79853-68108	Spacer Reference Sensor	79853-24702
6 Mirror #3 or #4	79853-68109	PTFE Ring 53C	79853-24500

Figure 5

Optical Unit "C" Inner Parts TOP



Optical Unit "C" Inner Parts Bottom

Table 5 Optical Unit "C" Inner Parts Bottom

Item Description	Part Nmber	Item Description	Part Nmber
Optical Unit (comple assembly)	79853-60015	7 Filter Assembly	see page 692
Plate Optical Base	79853-04109	7 Position Sensor Assembly, Filter	79853-61107
1 Optical Body	N/A	8 Cable Assembly, Sample	79853-61607
2 Plate Sample Sensor	79853-04110	9 Cable Assembly, Reference	79853-61608
3 Position Sensor Assembly, Grating	79853-61106	Spacer, Optical (metal foot)	79853-24701
4 Plate Reference Sensor	79853-04111	Insulator, Optical (rubber foot)	79853-85401
5 Spring #1, Grating	79853-29102	Foot Kit Optical	79853-22005
6 Grating Assembly	see page 691		

Figure 6

Optical Unit "C" Inner Parts Bottom



Grating Assembly

6	Grat	Grating Assembly				
	#	Description	Part number			
	1	Grating	79853-64605			
		Hex Screw M3 14 mm Ig				
	2	Spring #2, Grating	79853-29103			
	3	Gasket				
	4	Grating Motor Assembly	79853-64606			
	5	Screws M3 6 mm long				
		Photo Sensor	79853-61106			

Table 6

Figure 7

Grating Assembly



Filter Assembly

Table 7

Filter Assembly

Description	Part number	
1 Filter Assembly	79853-67903	
2 Lever Position Sensor		
3 Position Sensor Filter	79853-61107	
4 Screws M3 6 mm long		
	Description1 Filter Assembly2 Lever Position Sensor3 Position Sensor Filter4 Screws M3 6 mm long	DescriptionPart number1 Filter Assembly79853-679032 Lever Position Sensor33 Position Sensor Filter79853-611074 Screws M3 6 mm long4

Figure 8 **Filter Assembly**


Standard Flow Cell "C" (SST/Ti)

Table 8

Standard Flow Cell "C" (SST/Ti)

ltem	Description	Part Nmber	Qty
1	Cell Screw	79853-27201	
2	Conical Spring 10/pk	79853-27203	10
3	Ring 2/pk	79853-27202	2
4	Gasket #1 PTFE		
5	Window Quartz		
6	Gasket #2 PTFE		
7	Gasket #3 PTFE		
	STD Flow Cell 8 mm SST	see Note below	
	STD Flow Cell 8 mm Ti	79853-60011	
	PEEK Inlet Tubing Kit	5062-8522	
	Cell Kit STD, includes items 4 (2x), 5 (2x), 6 (1x) and 7 (1x)	79853-68718	
5	Window Quartz Kit	79853-68719	2
4	Gasket #1 PTFE Kit STD 10/pk	79853-68720	10
6	Gasket #2 PTFE Kit STD 5/pk	79853-68721	5
7	Gasket #3 PTFE Kit STD 5/pk	79853-68722	5

NOTE The original STD flow cell 79853-60008 was replaced in June 1995 by the "D" version 79853-60000. For parts ID refer to "Standard Flow Cell "D" Repair Parts" on page 710.

VWD: Parts Information
Standard Flow Cell "C" (SST/Ti)



Semi-Micro Flow Cell (SST)

Table 9

Semi-Micro Flow Cell (SST/Ti)

ltem	Description	Part Nmber	Qty
1	Cell Screw (same as STD)	79853-27201	
2	Conical Spring (same as STD)	79853-27203	10/pk
3	Ring (same as STD)	79853-27202	2/pk
4	Gasket #1 PTFE (same as STD) 10/pk	79853-68720	10/pk
5	Window Quartz (same as STD)	79853-68719	2/pk
6	Gasket #2 PTFE Micro	79853-68724	10/pk
	Semi-Micro Flow Cell (complete)	79853-60010	
	PEEK Capillary 400 mm lg ID 0.12 mm	5021-1823	
	Fitting for PEEK capillary	0100-1516	2/pk
_	Cell Kit Micro, includes items 4 (2x), 5 (2x) and 6 (2x)	79853-68723	

Figure 10

Semi-Micro Flow Cell (SST)



ltem	Description	Part Nmber	Qty
1	Cell Screw (same as STD)	79853-27201	
2	Ring POLYIMIDE		
3	Window Quartz	79853-68740	2/pk
4	Gasket #1 POLYIMIDE	79853-68729	10/pk
5	Gasket #2 POLYIMIDE	79853-68730	5/pk
	High Pressure Flow Cell SST	replaced by UHP Cell, see <i>"Ultra High Pressure Flow Cell</i> (SST)" on page 697	
	PEEK Tubing Assembly	5062-8522	
	Cell Kit HP, includes items 2 (2x), 3 (2x), 4 (2x) and 5 (1x)	79853-68728	

High Pressure Flow Cell (SST)

Ultra High Pressure Flow Cell (SST)

Table 11

Ultra High Pressure Flow Cell (SST)

ltem	Description	Part Nmber	Qty
1	Cell Screw	79853-27200	
2	Ring PEEK UHP		
3	Window Quartz Kit, UHP	79853-68734	2/pk
4	Gasket #1 POLYIMIDE Kit UHP	79853-68737	2/pk
5	Gasket #2 POLYIMIDE Kit UHP	79853-68738	2/pk
	Ultra High Pressure Flow Cell SST	79853-60013	
	PEEK Tubing Assembly	5062-8522	
	Cell Kit UHP, includes items 2 (1x), 3 (2x), 4 (2x) and 5 (2x)	79853-68733	

Figure 11

Ultra High Pressure Flow Cell (SST)



Preparative Flow Cell (Ti)

Table 12

Preparative Flow Cell (Titanium)

ltem	Description	Part Nmber	Qty
1	Cell Screw (same as STD)	79853-27201	
2	Conical Spring (same as STD)	79853-27203	10/pk
3	Ring (same as STD)	79853-27202	2/pk
4	Gasket #1 PTFE (same as STD)	79853-68720	10/pk
5	Window #1 Quartz (same as STD)	79853-68719	2/pk
6	Gasket #2 PTFE (0.1) for 0.9 µI		
6	Gasket #2 PTFE (0.2) for 1.8 µl		
6	Gasket #2 PTFE (0.5) for 4.4 µI		
6	Gasket #2 PTFE (1.0) for 8.8 µl		
7	Window #2 Quartz		
8	Gasket #3 PTFE		
	Preparative Flow Cell (complete)	79853-60012	
	PEEK Tubing Assembly	5062-8522	
	Cell Kit PREP, includes items 4 (1x), 5 (1x), 6 (1 of each size), 7 (1x) and 8 (1x)	79853-68725	
	Window Quartz Kit PREP includes items 5 (1x), 7 (1x)	79853-68726	
	Gasket Kit PREP includes one of each size of gasket #2	79853-68727	

VWD: Parts Information
Preparative Flow Cell (Ti)

Figure 12

Preparative Flow Cell (Ti)



Cuvette Holder

Control Module Parts

Table 13

ltem	Description	Part Number
	Cuvette Holder	79853-60016

For information the use of the cuvette holder, refer to "Using the Cuvette Holder" on page 658.

Figure 13 Cuvette Holder



Accessories

These parts are shipped with the 79853C VWD

Table 14

Accessories

Description	Part number	ΩΤΥ
Manual Getting Ready	01050-90211	1
Cable Remote	5061-3378	1
PEEK Waste Accessory Kit	5062-8535	1
Standard Accessory Kit	79853-68701	1
includes		
Fitting	0100-1516	1
Fuse 250 V 2A	2110-0002	3
Fuse 250 V 3A	2110-0003	3
Wrench 1/4-5/16 inch	8710-0510	1
Screwdriver POZI 1 PT 3	8710-0899	1
Leak Interface Kit	79853-68731	1
Manual SOP	79853-90009	1

Screws

Below table lists all screws within the instrument. They can be bought locally, if needed.

Table 15

Location	Size	Length	Туре
filter motor	M 2.3	4 mm lg	hexagon socket set screw with cup point
grating motor	M 3	3 mm Ig	hexagon socket set screw with cup point
mirror adjustment	M 3	8 mm lg	hexagon socket set screw with dog point
grating adjustment	M 3	14 mm lg	hexagon socket cap screw
grating motor	M 3	4 mm lg	countersink screw
to fix assemblies on the optical body; cover on the DCB board; plate of lamp house; KDI and VFD board; mirrors, filter and grating;	M 3	6 mm lg	screw
position sensor	M 3	6 mm lg	screw with smaller head
REF sensor plate	M 3	10 mm lg	screw
SAMP and REF amplifier boards	M 3	18 mm lg	screw
cover assembly; optical unit top cover; DCB and GPIB boards from rear panel;	M 4	6 mm lg	screw with lock washer
to fix assemblies on the base; DCB abd GPIB board; leak detector assembly; front panel bracket; SAMP and REF covers; optical unit bottom cover; blank screws of optical unit top cover; plate for cell on the optical body;	M 4	5 mm lg	screw
blank plate of cell; lock screws	M 4	12 mm lg	screw

VWD: Parts Information **Screws**

Table 15

Screws

Location	Size	Length	Туре
lamp house	M 4	14 mm lg	screw
fan assemblies	M 4	35 mm lg	screw
cell	M 5	10 mm lg	screw

All screws are plus-shaped type.

VWD: Parts Information **Screws**

1

VWD: Enhanced Optical Unit Information

This chapter provides information about the enhanced optical unit "D"

VWD: Enhanced Optical Unit Information

Since June 1995, the design of the optical unit for the 79853C Variable Wavelength Detector (VWD) was changed to improve its performance under unstable temperature conditions.

Together with the enhanced optical unit ("D"), the standard flow cell was changed (79853-60000).

In this document the term "D" is used for the new enhanced optical design and "C" for the original optical design.

Compatibility

This new enhanced optical unit ("D") is fully backward compatible with all 79853C VWDs shipped since January 1992.

The new standard flow cell (79853-60000) is backward compatible with the "C" optical unit.

Some of the parts for the enhanced optical unit ("D") are not usable in the "C" version.

In case of replacing a "C" optical unit with an enhanced "D" optical unit, the new standard flow cell is required.

Support of Previous Optical Units

The parts for the "C" optical unit will continue to be available as a repair part as long as the 79853C is supported (08/2006). In case the complete "C" optical must be replaced, use the "D" upgrade mentioned on "*Part Numbers for Enhanced "D" Optical Unit" on page 709*.

Introduction

To overcome wander problems due to temperature variations of the lab environment, the optical unit of the 79853C Variable Wavelength Detector (VWD) has been modified.

Following hardware modifications were implemented in June 1995:

- different coupling of the lamp housing (lens between lamp housing and optical casting).
- area around mirror M1 and M2 has been redesigned to eliminate one mirror result is a mirror #1 assembly with a plane mirror.
- redesigned entrance slit holder. Slits are changeable (standard/test).
- beam splitter assembly no longer vertically adjustable.
- reference slit assembly redesigned for better optimization.
- new standard flow cell with different aperture material and different inlet capillary.

Figure 1 Optical Path of Enhanced Optical Unit



Support Considerations

Prefix Change

The enhanced Optical Unit ("D" version) was introduced in production units in June 1995. Since the detector appears to look the same as before, a prefix change was made. All units with prefix **3522 J 04305** and above have the new optical installed.

Some units with a prefix lower than 3522 J 04305 have been installed on customer sites prior to the official shipments.

Identification

Following identifications for the enhanced "D" version are available:

- Prefix and serial number 3522 J 04305 and above (rear of instrument)
- firmware revision 4.31 (press CTRL 12 ENTER ENTER DOWN)
- label on the optical unit "ENHANCED ILLUMINATION SYSTEM"
- handle of new reference slit looking out of the optical's cover plate (see Figure 266 on page 715).

Compatibility Matrix

Due to a redesign, several components are usable in the enhanced "D" version only. Refer to Table 191 on page 709 for details.

NOTE Both optical unit versions ("C" and "D") can be operated with firmware revision 4.24 (79853-13005). Due to the modifications, the photocurrent readings are about 50% of those of the original "C" opticals. To make them comparable the firmware for the enhanced "D" version got a new revision and part number.

Part Numbers for Enhanced "D" Optical Unit

Table 1	Enhanced "D" Version Part N	Part Numbers		
Part Number	Description	Comments		
79853-60000	Standard Flow Cell	backward compatible [*] , for details see Table 192 on page 710.		
79853-69014	Exchange "D" Optical includes firmware 79853-13000	when "D" optical should be replaced, needs Standard Flow Cell 79853-60000		
79853-69015	Exchange "D" Optical includes a Standard Flow Cell 79853-60000 and firmware 79853-13000	when "C" optical should be replaced		
79853-68110	"D" Mirror 1 Assembly	for "D" only, includes test slit		
79853-68111	"D" Mirror 3/4 Assembly	backward compatible ** , includes test slit		
79853-68112	"D" Beam Splitter	for "D" only, includes test slit		
79853-68113	"D" Lens Assembly	for "D" only, includes test slit		
79853-66508	Pre-amplifier Board REF	from "C" used for SAMPLE and REFERENCE on "D"		
79853-61109	Diode Sample	from "C" used for SAMPLE and REFERENCE on "D"		
79853-64605	Grating Assembly	same part number as before, but test slit added		
79853-13000	Firmware "D" rev 4.31	for "D" only, added also to 79853-69014/15 and 79853-69511 (DCB)		
79853-68746	Slit Kit "D"	Test slit plus STD slit		

* with "C" version optical units

** with "C" version optical units; part number 79853-68109 should only be used for 79853C optical until stock has expired.

NOTEThe part numbers 79853-68110, -68111, -68112, -68113 and -64605 include
beside the test slit in addition a seal to close the hole for Mirror 4 adjustment
setscrew. Close the hole with this seal during replacements (see Figure 266 on
page 715 for the location).

Standard Flow Cell "D" Repair Parts

Table 2

Standard Flow Cell "D" Repair Parts

ltem	Description	Part Number
	STD Flow Cell "D", complete assembly	79853-60000
1	Cell Screw	79853-27200
	Kits:	
	Cell Kit STD "D", consists of: two windows, two gaskets #1, one gasket #2 and one gasket #3.	79853-68741
2	Conical Spring "D", Qty=10	79853-29100
3	Ring SST "D", Qty=2	79853-22500
5	Window Quartz "D", Qty=2	79853-68742
4	Gasket #1 "D", PTFE, Qty=10	79853-68743
6	Gasket #2 "D", Aperture, gold, Qty=5	79853-68744
7	Gasket #3 "D", PTFE, Qty=5	79853-68745

Figure 2

Standard Flow Cell "D" Repair Parts



Repair and Mainenance

WARNINGThese procedures need special knowledge on servicing the 79853CVWD and should be done by trained Service Engineers only.

These procedures should be carried out in a room where the light can be reduced.

Since the deuterium lamp emits intensive ultraviolet light, it is dangerous to perform optical alignment without eye protection.

Tools required:

- □ Test Slit (supplied with mirror or grating assembly)
- Pozi Driv PT1
- □ hexagonal wrench (1.5 mm)
- □ hexagonal wrench (2.5 mm)
- □ pair of tweezers (not too sharp points)

Pre-requisites:

- □ Assure that the flow cell is clean, flushed with water and bubble free.
- □ Remove detector from system.
- □ Place the detector on a bench.
- **□** Remove the main cover.

Additional Information

For additional information about replacements and the use of the Service control Functions refer to *"VWD: Maintenance Information" on page 649* and *"Service Control Functions" on page 622.*

	Replacements and Calibrations				
	The following procedures describe the replacements of parts separately.				
NOTE	It is important that only one assembly (mirror, grating, beam splitter,) is changed and calibrated at a time. Otherwise you will lose correct optical assembly alignment during the calibration process.				
WARNING	Do not remove the Entrance Slit Holder nor loosen it. Otherwise the optical unit has to be exchanged completely.				
NOTE	The photocurrent readings with test slit installed are much lower than with the standard slit.				



test slit

VWD: Enhanced Optical Unit Information Installing the Test Slit

5 Carefully insert the test slit (with round hole) into the entrance slit holder. The slit must sit flat on the holder with the white side towards the incoming light.



Replacing Mirror #3 or #4 Assembly

	NOTE	Replace and calibrate o	ne mirror at a time.
--	------	-------------------------	----------------------

- 1 Install the test slit, see "Installing the Test Slit" on page 713.
- **2** Carefully replace the cover of the optical unit. Take care for the reference aperture handle, see Figure 266 on page 715.
- 3 Execute CTRL 20: 0th CALIB.
- 4 Activate service function CTRL 40: 0TH TEST ON.
- **5** Carefully remove the cover of the optical unit. Take care for the reference aperture handle, see Figure 266 on page 715.
- **6** Unlock the reference aperture, "Unlocking the Reference Aperture" on page 723.
- 7 Center the reference slit on the white image by moving the aperture up or down, see Figure 267. The image diameter is nearly equal to the reference slit diameter.

Figure 5 Algning the Reference Slit



- 8 Install new mirror #3 or #4 assembly.
- 9 Position the white image precisely onto the reference slit:
 - horizontally by rotating the mirror,
 - vertically using the setscrew of the mirror
- **10** Carefully replace the cover of the optical unit. Take care for the reference aperture handle.
- 11 De-activate CTRL 40: 0TH TEST OFF, press CLEAR, CLEAR and BALANCE.
- 12 Set λ =250 nm.
- 13 Activate CTRL 16: PHOTOCURRENT.
- 14 Optimize the sample readings using the setscrew of mirror #4 through the hole in the optical unit cover, see Figure 266 on page 715.
- **15** Optimize the reference readings with the reference aperture, see "Optimizing the Reference Readings" on page 725.
- **16** Install the standard slit and perform electronic calibrations, see "Installing the Standard Slit" on page 726.

	Replacing the Grating or Grating Motor
NOTE	To replace the Grating and/or the Grating Motor refer to " <i>Replacing Grating Assembly Parts</i> " on page 668 and continue with the Alignment Procedure below.
1	Install the test slit, see "Installing the Test Slit" on page 713.
2	Carefully replace the cover of the optical unit. Take care for the reference aperture handle, see Figure 266 on page 715.
3	Execute CTRL 20: Oth CALIB.
4	Activate service function CTRL 40: OTH TEST ON.
5	Carefully remove the cover of the optical unit. Take care for the reference aperture handle, see Figure 266 on page 715.
6	Unlock the reference aperture, see "Unlocking the Reference Aperture" on page 723.
7	De-activate CTRL 40: OTH TEST OFF.
8	Center the reference slit on the white image by moving the aperture up or down. The image diameter is nearly equal to the reference slit diameter.
9	Remove the grating and reassemble new grating.
NOTE	Assure that the grating is not fixed on the shaft with the setscrew.
10	Set the Param. λ =200, using service function CTRL 31: SET λ PARAM.
11	Activate service function CTRL 40: OTH TEST ON.
12	Turn the grating so that the center of the image is on the reference slit (a small horizontal and vertical deviation can be accepted).
13	Fix the grating with the setscrew.
14	De-activate and re-activate CTRL 40: 0TH TEST and check the position of the image on the reference slit.
	If not correct, loosen the grating and repeat steps 12 to 14.

- **15** Do a vertical adjustment with Mirror #4 for precise vertical fit of image on reference slit, using the setscrew of mirror #4 through the hole in the optical unit cover, see Figure 266 on page 715.
- **16** Carefully replace the cover of the optical unit. Take care for the reference aperture handle.
- 17 De-activate CTRL 40: OTH TEST OFF, press [CLEAR], [CLEAR] and [BALANCE].
- 18 Execute CTRL 20: Oth CALIB.
- **19** Activate CTRL 40: OTH TEST ON and readjust the Beam Splitter for ideal horizontal fit.
- 20 De-activate CTRL 40: OTH TEST OFF.
- **21** Set λ =250 nm.
- 22 Activate CTRL 16: PHOTOCURRENT.
- **23** Optimize the sample readings, using the setscrew of mirror #4 through the hole in the optical unit cover, see Figure 266 on page 715.
- **24** Unlock the reference aperture, see "Unlocking the Reference Aperture" on page 723.
- **25** Optimize the reference readings with the reference slit, see "Optimizing the Reference Readings" on page 725.
- **26** Install the standard slit and perform electronic calibrations, see "Installing the Standard Slit" on page 726.

Replacing the Beam Splitter

- 1 Install the test slit, see "Installing the Test Slit" on page 713.
- 2 Execute CTRL 20: Oth CALIB.
- **3** Carefully remove the cover of the optical unit. Take care for the reference aperture handle, see Figure 266 on page 715.
- **4** Activate service function CTRL 40: OTH TEST ON.
- **5** Unlock the reference aperture, see "Unlocking the Reference Aperture" on page 723.
- **6** Center the reference slit on the white image by moving the aperture up or down. The image diameter is nearly equal to the reference slit diameter.
- 7 Install the new beam splitter assembly.
- **8** Position horizontally the white image center of the beam splitter onto the reference slit.
- 9 Fix the beam splitter after precise image fit.
- 10 Correct new vertical position with reference slit.
- **11** Carefully replace the cover of the optical unit. Take care for the reference aperture handle.
- 12 De-activate CTRL 40: OTH TEST OFF, press [CLEAR], [CLEAR] and [BALANCE].
- 13 Set λ =250 nm.
- 14 Activate CTRL 16: PHOTOCURRENT.
- **15** Optimize the sample readings using the setscrew of mirror #4, using the setscrew of mirror #4 through the hole in the optical unit cover, see Figure 266 on page 715.
- **16** Optimize the reference readings, see "Optimizing the Reference Readings" on page 725.
- 17 Install the standard slit and perform electronic calibrations, see "Installing the Standard Slit" on page 726.

Cleaning or Replacing the Lens

The lens is located between lamp housing and casting and can be cleaned or replaced.

- **1** Turn the detector off.
- 2 $\,$ Disconnect the lamp connector and all other connectors to the DCB board.
- 3 Remove the optical unit completely from the instrument.
- 4 Unscrew the four screws of the lamp housing and remove lamp housing.



NOTE For easier repositioning the lens ring is marked with color paint, see Figure 269 on page 722. The position of the marker could differ from instrument to instrument and may be different to the position shown in the figure.

5 Remove, clean or replace the lens. If reusing old lens use markings for repositioning.

VWD: Enhanced Optical Unit Information Cleaning or Replacing the Lens





NOTE	The more plane lens side with smaller aperture faces towards the lamp.
NOTE	If a new lens is installed, mirror #1 assembly has to be realigned after this procedure, see "Replacing Mirror #1 Assembly" on page 715.
	6 Reassemble the flat spring.
	7 Replace the Lamp housing and tighten it.

 ${\bf 8} \ \ {\rm Reassemble \ the \ detector.}$

NOTE	Only necessary.	if required	during a re	placement	procedure.
	only necessary,	II ICquii Cu	auring are	placement	procedure.

For performance reasons, the reference aperture is fixed by one screw only and has to be unlocked prior to any replacement/calibration within the optical unit.

1 Unscrew the front panel and place it in front of the detector to have access to the reference pre-amplifier area.

NOTE When moving the front panel, assure that the keyboard cable is not partially disconnected - damage to the electronics is possible.

- **2** Unscrew the right screw of the reference pre-amplifier cover and loosen the left screw.
- **3** Turn the cover counter-clockwise until you can loosen the top screw of the photo diode holder sheet.

Figure 8

Unlocking the Reference Slit



VWD: Enhanced Optical Unit Information **Unlocking the Reference Aperture**

- 4 Replace the reference pre-amplifier cover (to prevent stray light).
- 5 Fit the front panel with one screw at the right of the mainframe.
- 6 Turn on the detector and the lamp
- 7 Set wavelength to 250 nm.
- 8 Return to your replacement procedure.

Optimizing the Reference Readings

- 1 Carefully replace the cover of the optical unit. Take care for the reference aperture handle.
- 2 Activate CTRL 16: PHOTOCURRENT.
- 3 Shift reference aperture vertically for maximum reference readings.
- 4 Fix the reference slit with the top lock screw of the photo diode assembly.
- **5** Replace the reference photodiode cover.
- **6** Continue with the next step of the procedure of the assembly you are replacing.

Optimizing the Reference Readings

Figure 9



Installing the Standard Slit

NOTE This procedure has to be carried out at the end of all replacement procedures.

- 1 Carefully remove the cover of the optical unit. Take care for the reference aperture handle, see Figure 266 on page 715.
- **2** Remove the test slit from the entrance slit holder using a pair of tweezers and place it safe.

Figure 10

Replacing the Entrance Slit



standard slit

- **3** Carefully insert the standard slit into the entrance slit holder. The slit must sit plane on the holder.
- **4** Carefully replace the cover of the optical unit. Take care for the reference aperture handle, see Figure 266 on page 715.
- 5 Execute CTRL 20: 0th CALIB.
- 6 Execute CTRL 21: 1 CALIBRATION.
- 7 Reassemble the detector.

1

VWD: Additional Information

This chapter provides additional information about the 1050 Variable Wavelength Detectors

VWD: Additional Information

Since the introduction of the 79853C Variable Wavelength Detector in 1991, the following hardware and firmware changes have been implemented.
Product History

Since introduction of the 79853C Variable Wavelength Detector in January 1992 following changes have been implemented.

Prefix Changes

Serial Number	Changes	Additional Information
3145 J 00101	Start of customer shipments	∅
3152 J 00263	New amplification factor of reference side due to high output of new DAD lamps.	See "Modified Pre-Amplifier Gain" on page 734.
3152 J 00489	Introduction of DCB firmware revision 4.22	See "SN 01050-055" on page 734.
3217 J 00603	Introduction of DCB firmware revision 4.23	See "SN 01050-055" on page 734.
3225 J 00773	Introduction of DCB firmware revision 4.24	See "SN 01050-055" on page 734.
3225 J 01801	Introduction of PTFE ring in optical unit	See "SN 01050-068" on page 734.
	Volume changes on Preparative Flow Cell in September 1992	See Table 138 on page 574 and Table 187 on page 698.
3225 J 02011	Introduction of new DCB/PSC boards	See "SN 01050-072" on page 734.
3323 J 03117	Introduction of new lamp housing	
3334 J 03255	Change of manufacturing process for photo diodes mounting	to improve stability against humidity
	Ultra High Pressure cell replaced High Pressure Cell in 1993	

Table 1

Prefix Changes

Serial Number Changes 3522 J 04305 Enhanced optical unit "D" with STD flow cell "D" in June 1995 to improve temperature stability, see "VWD: Enhanced Optical Unit Information" on page 705

DCB ROM Firmware Revisions

Table 2

DCB ROM Firmware Revisions

Revision	Major Changes	Comments
4.08		Used for first internal Waldbronn/Avondale units and some demo units.
4.09	PHOENIX problem: won't stop when running with A/D Concerter (for example ABORT).	Not released.Used for internal Waldbronn/Avondale tests.
4.21	CTRL 45 COMPENSATE bug fix, calibrated wavelength deviation might exceed the specification. CTRL 22 HOLMIUMCHECK for GLP reasons added.	Released for 79853C in January 1992. For replacements use part number 79853-13005 (4.24). NEEDS GPIB ROM version 0.20 or above (79853-13004)
4.22	New algorithm for CTRL 45 COMPENSATE and CTRL 22 HOLMIUMCHECK.	Released for 79853C in March 1992. Started with serial number 3152J00489. For replacements use part number 79853-13005 (4.24). NEEDS GPIB ROM version 0.20 or above (79853-13004)
4.23	Removed bug: Incorrect wavelength setting during stepper motor intialisation bewteen 536.4 nm and 600 nm.	Released for 79853C in April 1992. Started with serial number 3217J00603. For replacements use part number 79853-13005 (4.24). NEEDS GPIB ROM version 0.20 or above (79853-13004)

Table 2 DCB ROM Firmware Revisions

Revision	Major Changes	Comments
4.24	Removed bug : EEROM DATA LOST1 Removed bug : Wavelength accuracy between 360 nm and 486 nm	Released for 79853C in June 1992. Started with serial number 3225J00773. For replacements use part number 79853-13005 (4.24). NEEDS GPIB ROM version 0.20 or above (79853-13004)
4.31	For Enhanced Optical Unit "D" only	Released for 79853C in June 1995. Started with serial number 3522J04305. For replacements use part number 79853-13000 (4.31). NEEDS GPIB ROM version 0.20 or above (79853-13004)

GPIB ROM Firmware Revisions

The table below lists all GPIB ROM firmware revisions for the 79853A/C.

Table 3

GPIB ROM Revisions

Revision	Major Changes	Comments
0.04		First official realease for 79853A.
0.05	LC APPACK problem: BUFFER OVERFLOW message preventing run buffer overflow.	Released for 79853A.
0.08	Also useable for 79853C. PHOENIX problem: prevents hang-ups at power on (if VWD is switched on after PHOENIX has been switched on).	Released for 79853A and 79853C. For replacements use part number 79853-13004 (0.2X)
0.09	PHOENIX problem: prevents VECTRA 486 hang-ups.	NOT officially released.
0.20	additional changes for future PHOENIX enhancements.	Released for 79853A and 79853C in January 1992. Required for 79853C firmware revision 4.21 and above. For replacements use part number 79853-13004 (0.2X)

Hardware Changes and Service Notes

Modified Pre-Amplifier Gain

First instruments where shipped with a pre-amplifier gain of 100% on the reference side. The new deuterium lamps (79883-60002) showed sometimes very high energies which gave very high numbers on the reference side 16 : PHOTOCURRENT. To prevent an overload the amplification factor was changed to 75%. The feedback resistors on the reference side changed from 200 MOhm to 150 MOhm and on the sample side from 100 MOhm to 75 MOhm.

NOTE No revision change was made. The modified pre-amplifiers started with serial number 3145J00263.

Important Service Note

SN 01050-055	Service Note 1050-055 describes the introduction of the DCB firmware revision 4.24 and the problems with previous revisions in more detail.
SN 01050-068	This note describes problems with POM ring between lamp housing and optical casting. Exchange POM ring against PTFE Ring 53C (79853-24500).
SN 01050-072	This note describes problems with negative baseline jumps on analog output signal. New DCB (79853-66511) and PSC (79853-66512) Boards have been introduced.
SN 01050-085	This note describes the optimization for drift problems.
SN 01050-104	Introduction of Enhanced Optical Unit, see "VWD: Enhanced Optical Unit Information" on page 705.
SN 01050-107	Cuvette Holder for Wavelength Verification with Certified Standard Solutions available see "Cuvette Holder" on page 700.
SN 01050-112	Check of photometric accuracy - information on path lengths of flow cells, see "Correction factors for 79853C flow cells" on page 575.



In This Book

This manual contains technical information about the Agilent 1050 liquid chromatographs.

This manual is available as electronic version (Adobe Acrobat Reader file) only.